

WEBINAR

Industrial applications of micro-XRF – Quality control at different stages

Bruker Nano Analytics - Micro-XRF applications



The speakers



- Falk Reinhardt
- Senior Application Scientist,
Bruker Nano Analytics, Berlin, Germany

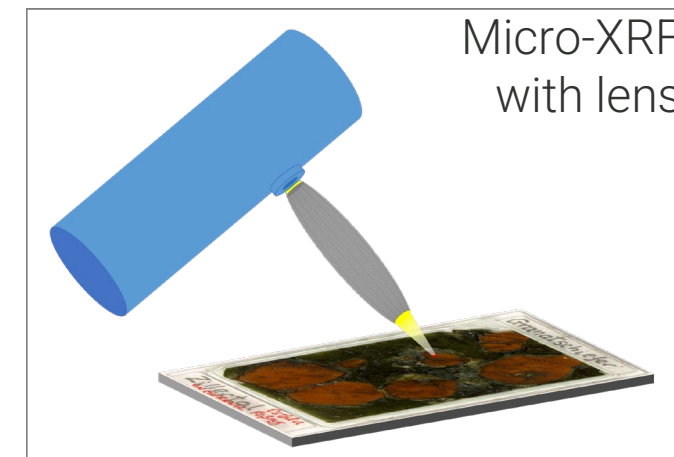
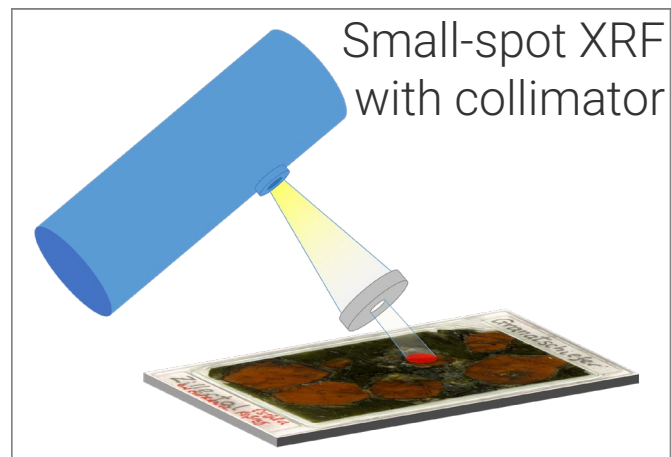
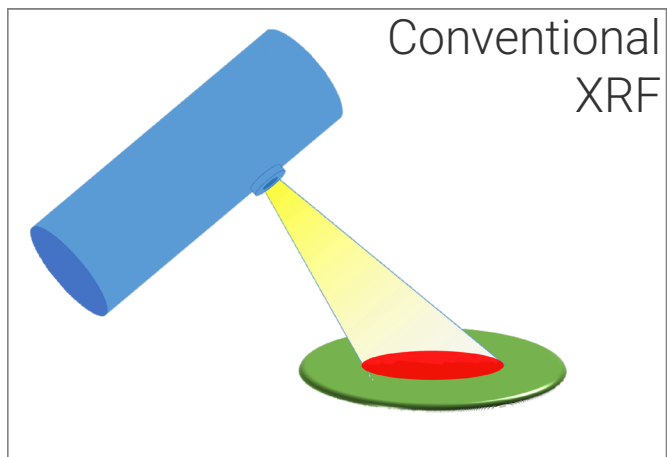


- Dr. Christian Hirschle
- Application Scientist,
Bruker Nano Analytics, Berlin, Germany

Agenda

- | | | | |
|---|--|---|--|
| 1 | Introduction | 5 | Process control |
| 2 | Micro-XRF in general | 6 | Quality control –
Qualitative analysis |
| 3 | Incoming goods inspection –
Qualitative analysis | 7 | Quality control –
Quantitative analysis |
| 4 | Incoming goods inspection –
Quantitative analysis | 8 | Summary and Q&A session |

From XRF to micro-XRF



Composition



Compositional variations



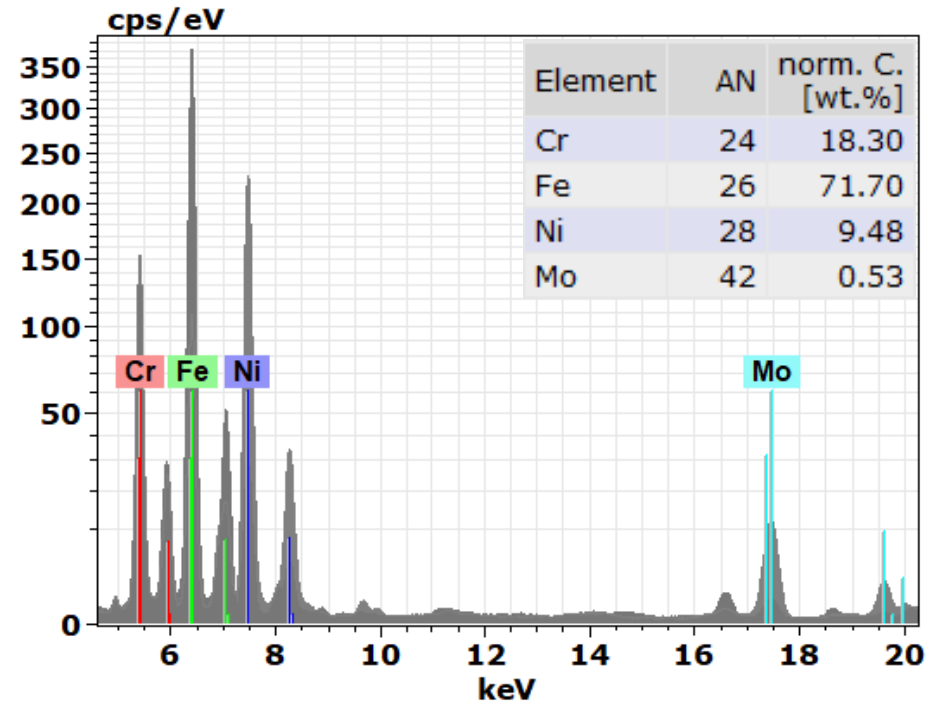
From XRF to micro-XRF

- Conventional X-ray fluorescence analysis (XRF) is an analytical tool for qualitative and quantitative material analysis. It performs ideally in a **standardized workflow**.
- XRF tells you **which** elements are in the sample and **how much** of each one.
- Usually a sample needs “**preparation**”, including **homogenization** and/or **dilution** for matrix reduction.



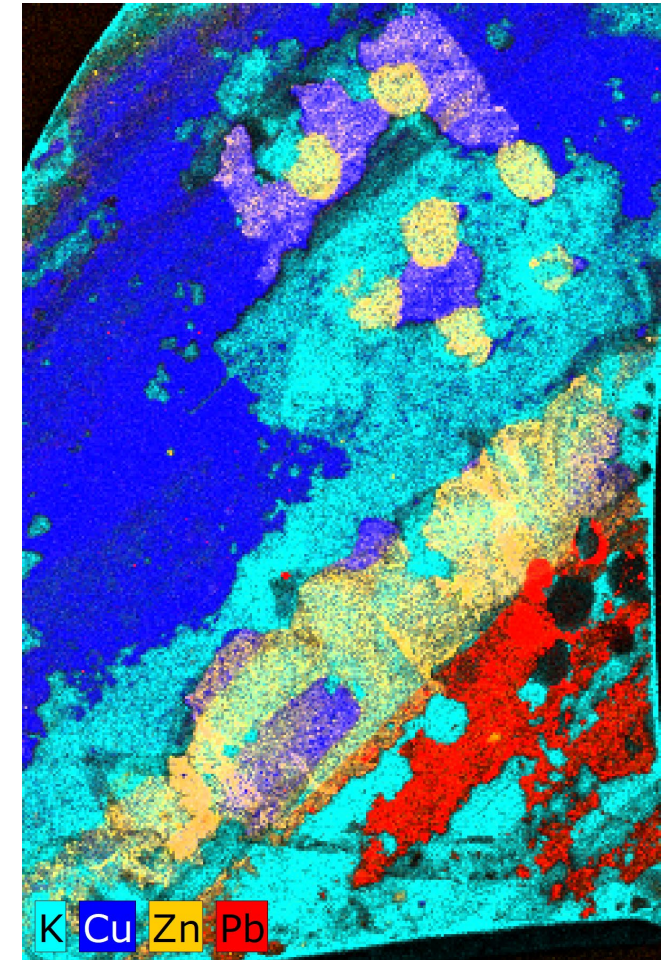
Information is lost!

The compositional variations in a sample may be a crucial property of the material!



Micro-XRF

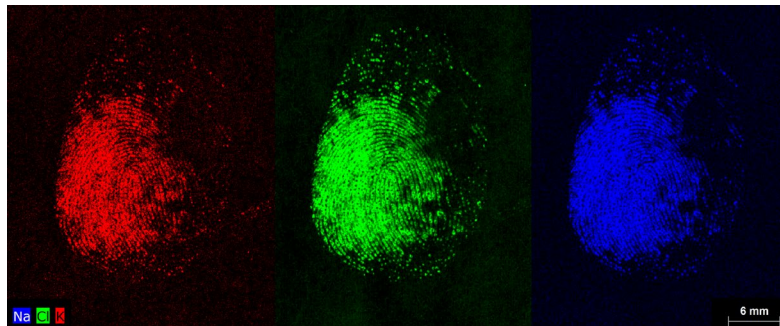
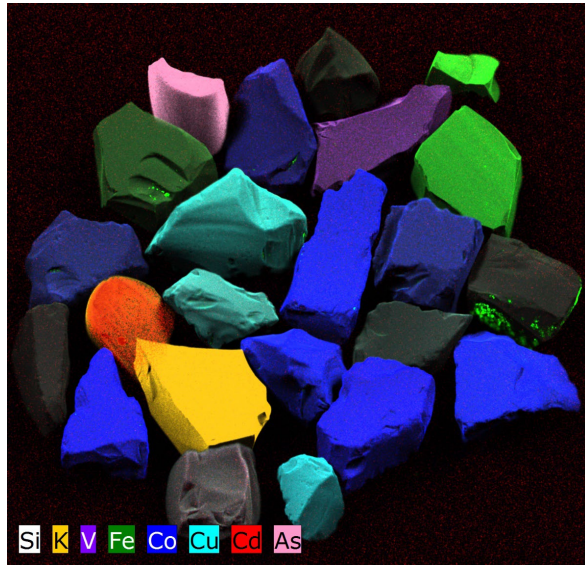
- Micro-XRF is XRF with a small spot (nowadays typically $< 20 \mu\text{m}$).
 - Micro-XRF reveals where elements are.
 - Micro-XRF is ideal for non-homogeneous samples.
- It usually requires minimal or no sample preparation.
- **Quantitative micro-XRF** is feasible for sufficiently homogeneous areas of the sample, which can be even below $100 \mu\text{m}$ in diameter.
- The measurement conditions are very flexible in order to address different analytical tasks or requirements posed by the sample.



Micro-XRF

What is it used for?

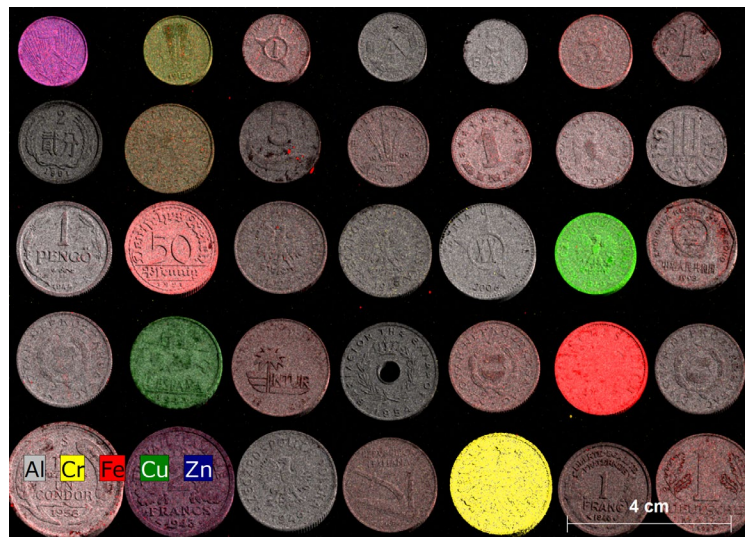
- Forensics and life sciences



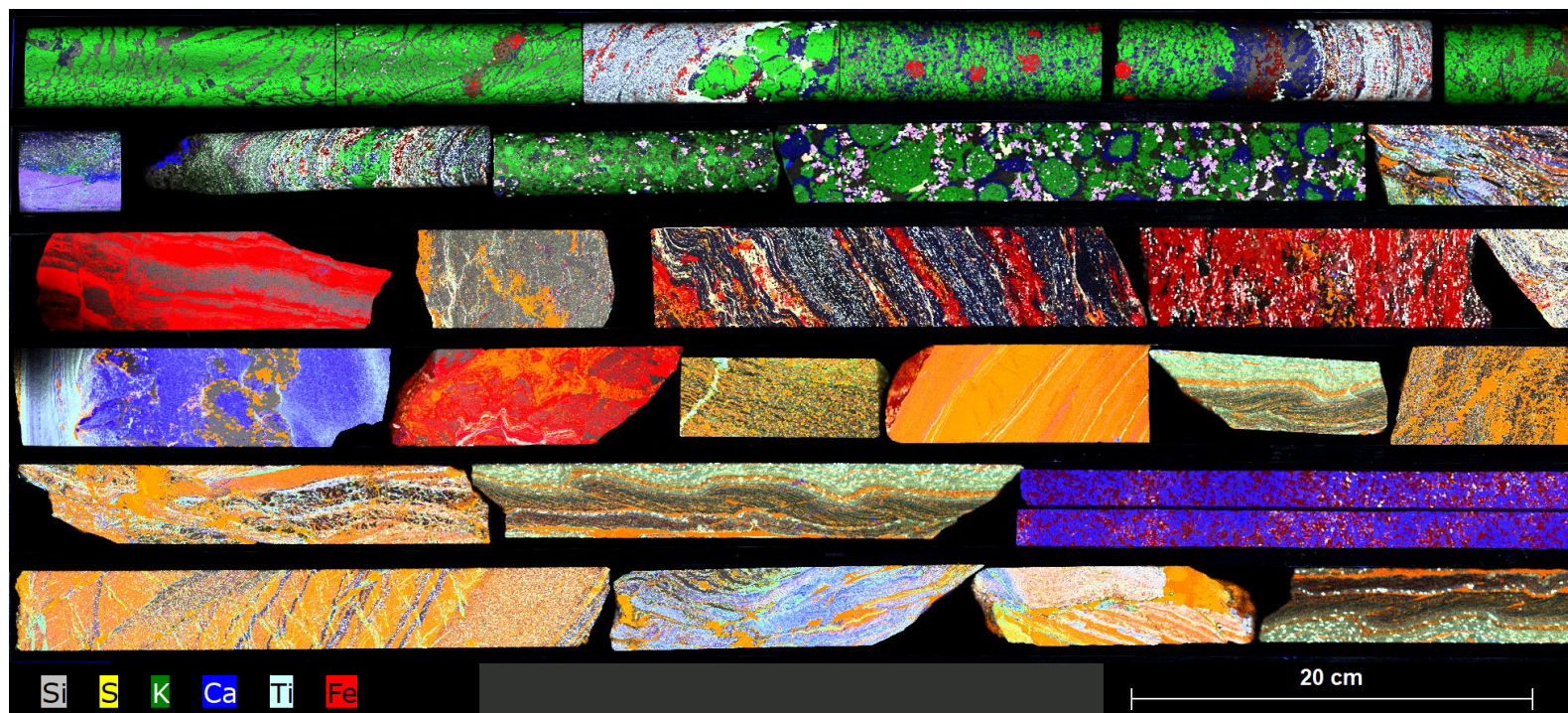
Micro-XRF

What is it used for?

- Art, conservation, archaeology



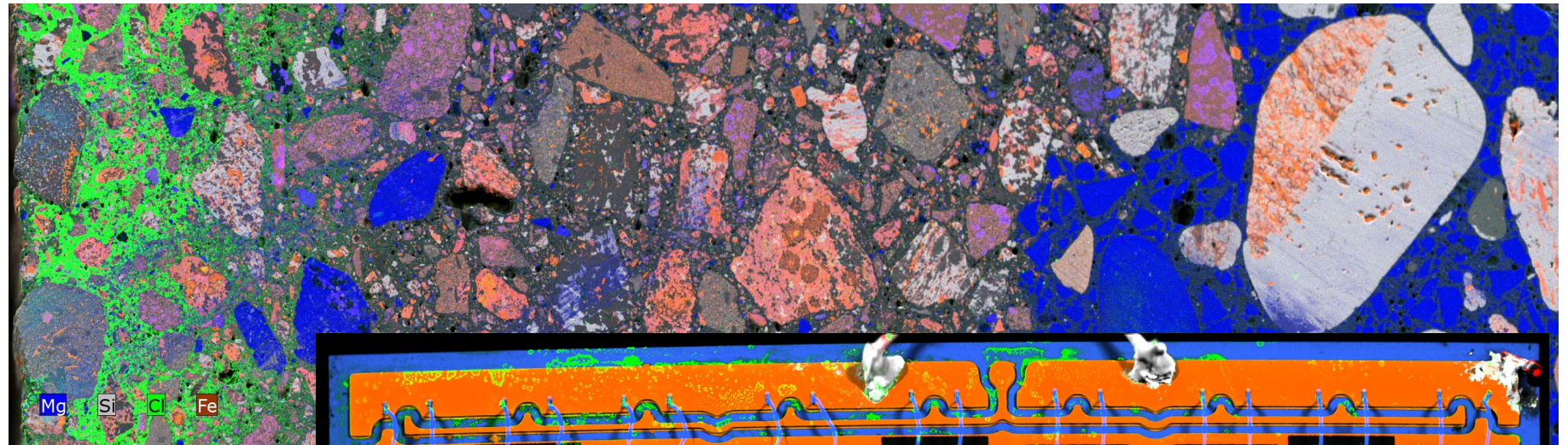
- Geology



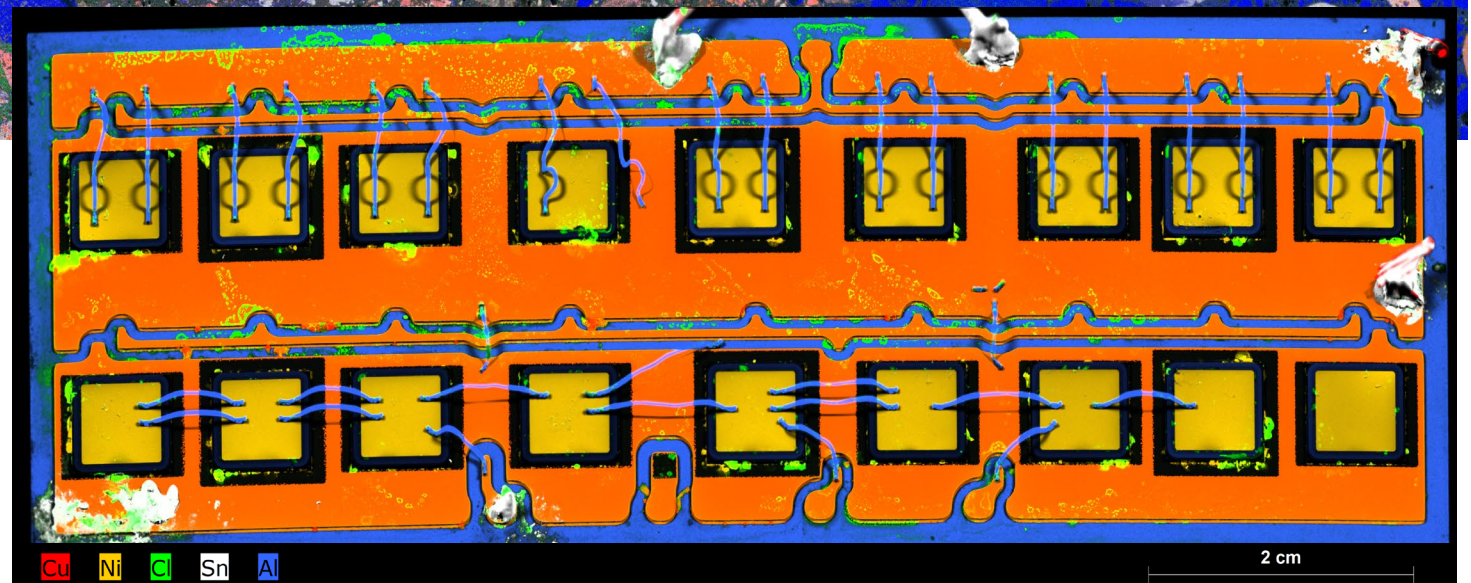
Micro-XRF

What is it used for?

- Materials science



- R&D



Micro-XRF

Uses in industrial environment

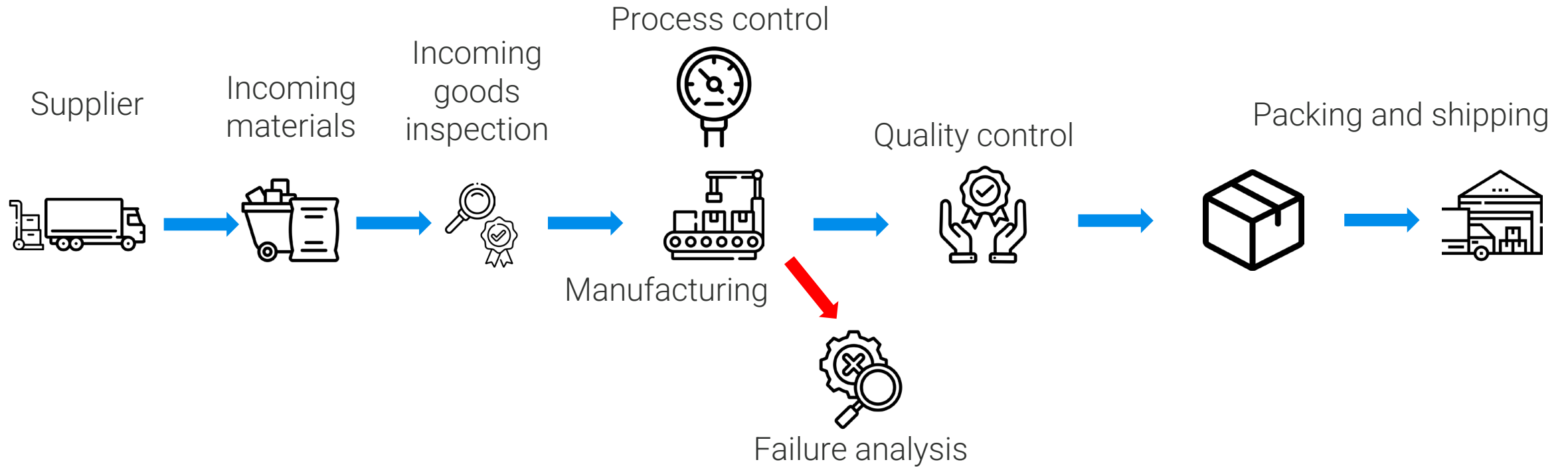
- Micro-XRF is well established in academic environment and the R&D or central labs of large companies.
... but where does it fit in a more industrial environment?

- Even though it is possible to operate the M4 TORNADO in an automated environment, this will not be the topic of this presentation.
- We will discuss the standard operation of the instrument and where its analytical methods are beneficial in an industrial workflow.



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<https://groups.chem.ubc.ca/cberling/research/>

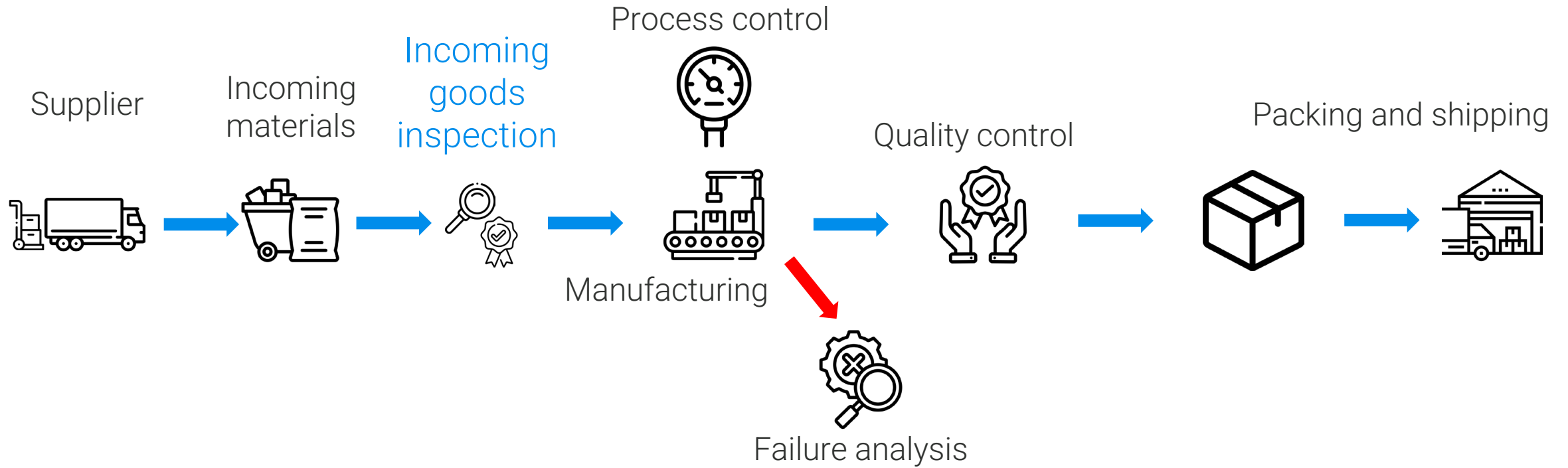
Micro-XRF – Quality control at different stages



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Micro-XRF – Quality control at different stages

Incoming goods inspection

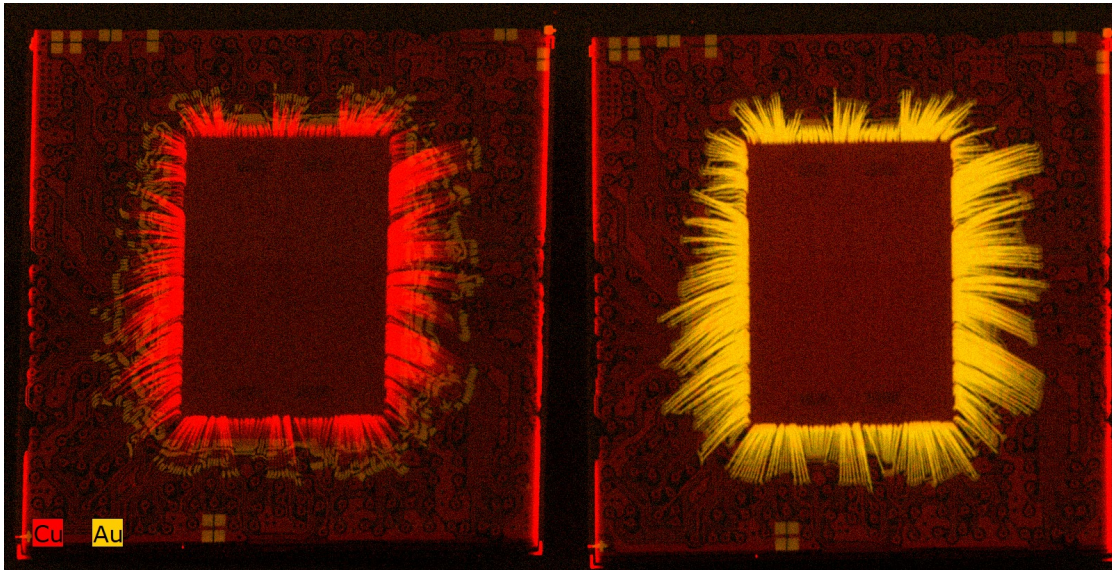


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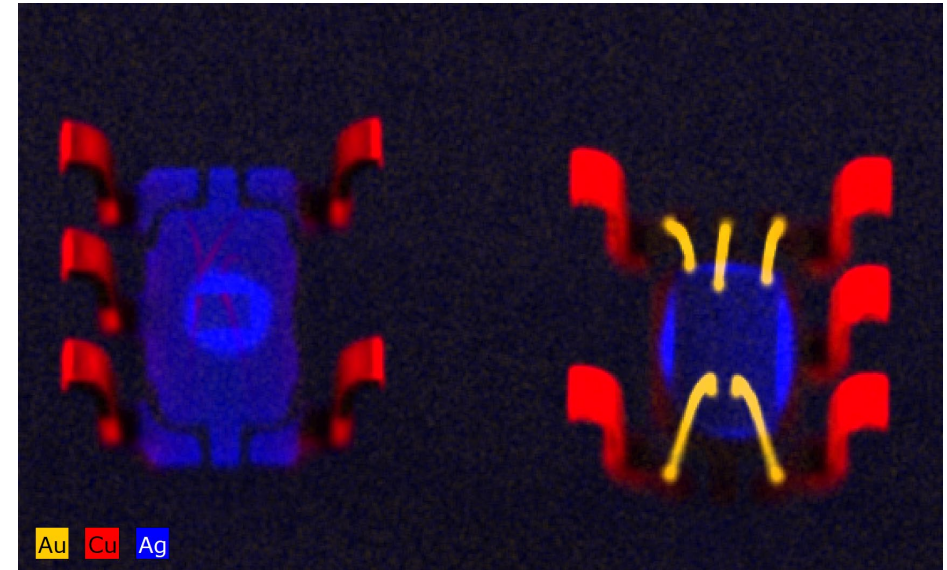
Incoming goods inspection

Qualitative analysis

- Updated chip design, announced by the manufacturer:
 - Copper wires instead of gold to save costs.



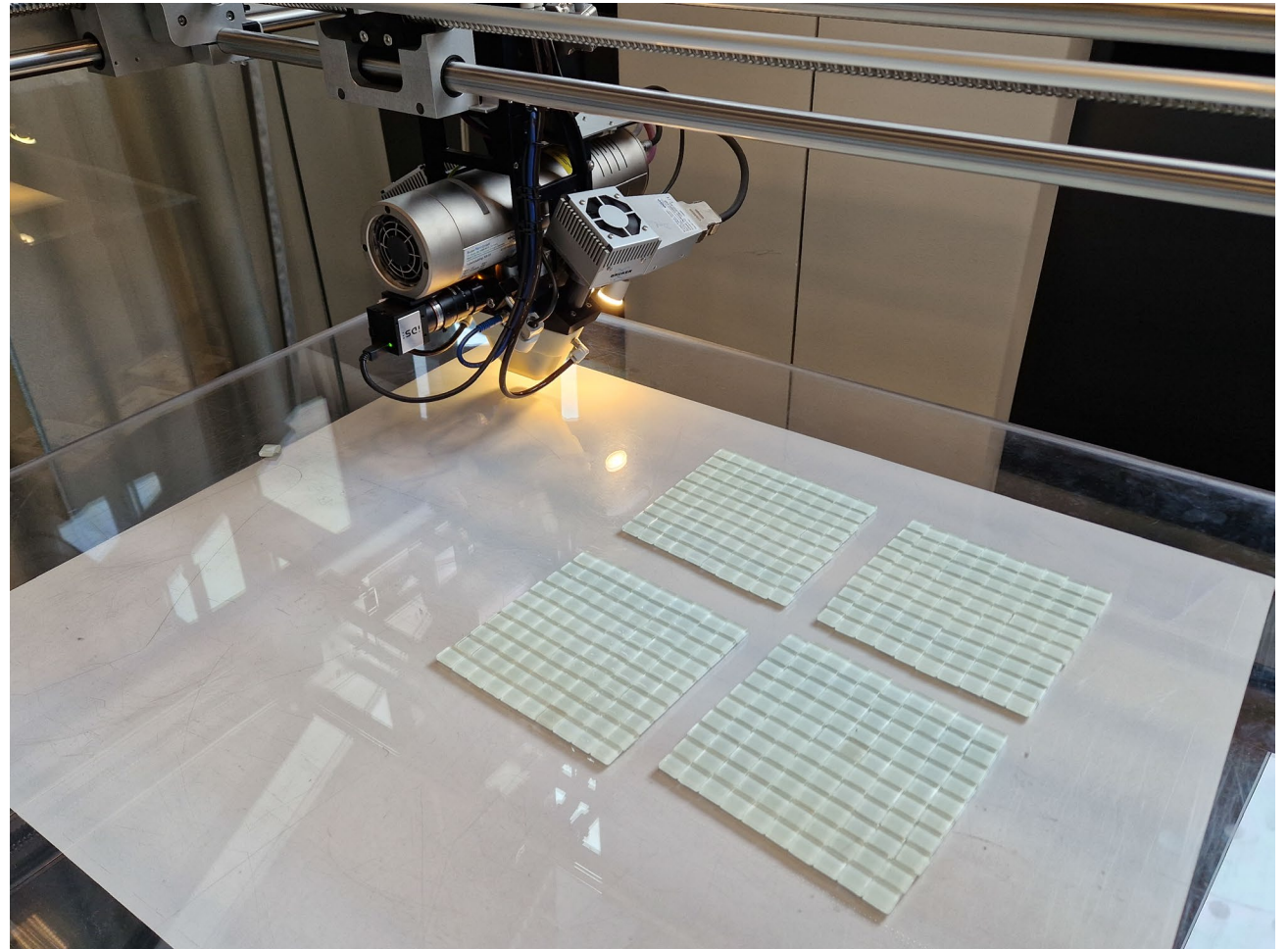
- Here a new supplier sent a batch of ICs with the same designation who behaved differently when tested.
- Micro-XRF showed a different inner design.



Incoming goods inspection

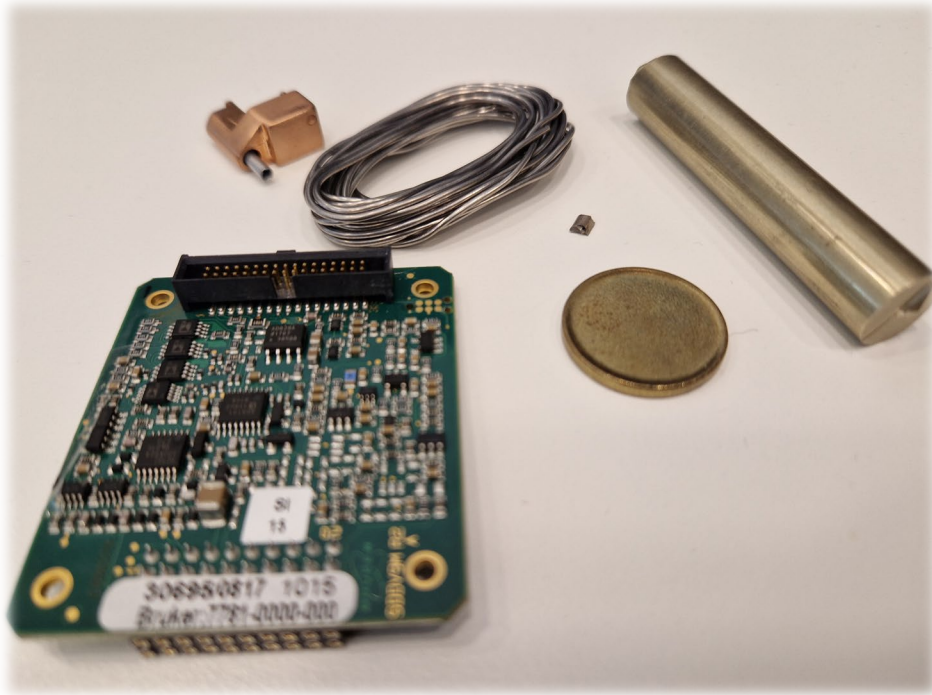
Qualitative analysis

- With sufficiently clear criteria (Au wires in ICs) even qualitative analysis can be done as point measurements, maybe with collimator.
- Example here: in batches of glass tiles, a specific subset of potassium-rich tiles needs to be identified.



Incoming goods inspection

Quantitative analysis – Introduction

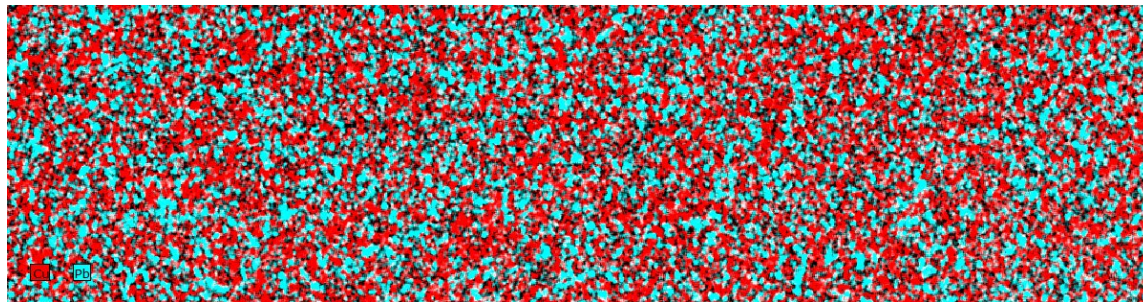


Some challenging samples

- When using metal alloys as raw materials a quantitative analysis of incoming goods is vital.
- Next to OES, XRF is the most common method for incoming goods inspection, be it handheld, benchtop or floor-standing.
- When the samples are too small for larger instruments, micro-XRF can be used with high results quality.
- Also, it has the benefit of being relatively forgiving when it comes to adverse sample shapes.
- However, like for most techniques, a more sophisticated sample preparation (flat surfaces) and thorough sample placement (horizontal alignment) greatly improves the attainable quality of the results.

Incoming goods inspection

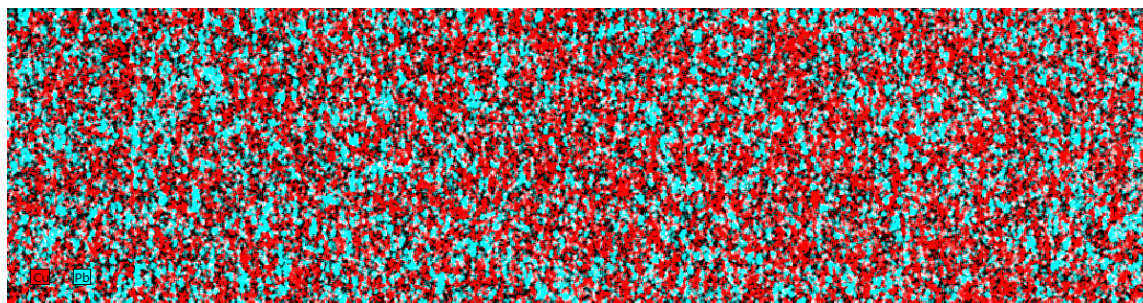
Quantitative analysis – Copper alloys



BAM

ERM-EB 375

Cu 58 %, Zn 39 % Pb 2.9 %



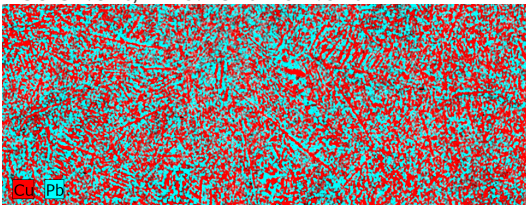
ARMI

CDA 360 73B

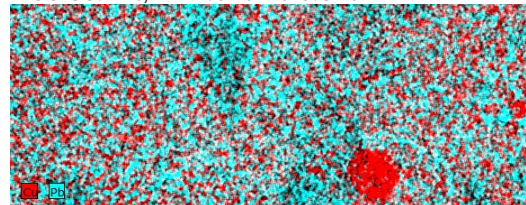
Cu 61.5 %, Zn 35.5 % Pb 1.9 %

LGC Standards
SUS RC36

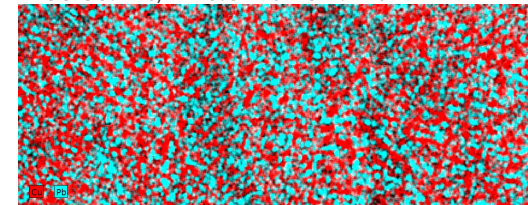
Cu 82.5 %, Zn 0.25 % Pb 9.6 %

ARMI
CDA 932

Cu 83.2 %, Zn 2.6 % Pb 6.8 %

ARMI
CDA 397

Cu 80.2 %, Zn 0.04 % Pb 9.2 %



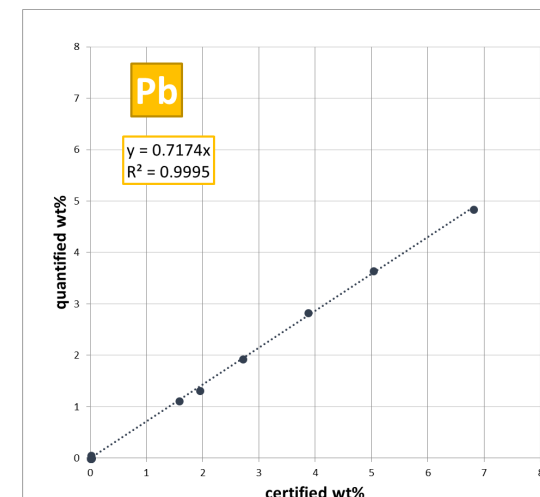
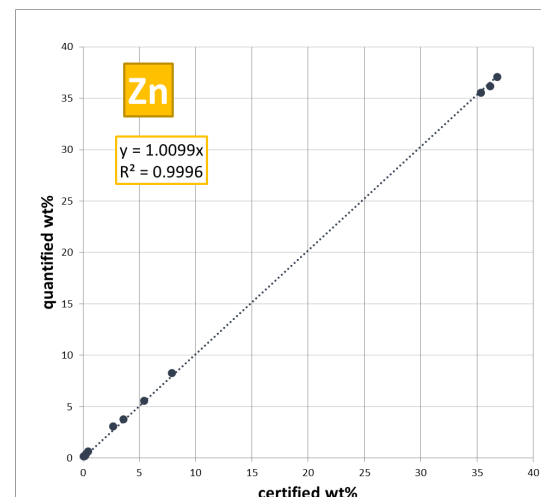
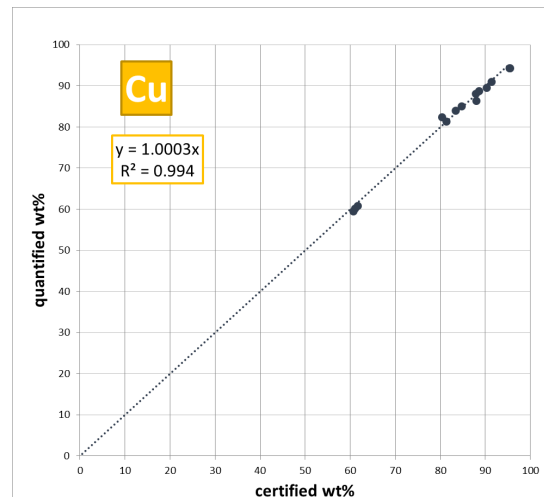
- Element distribution in bronzes
- The alloy is clearly inhomogeneous, because the lead (added as cutting aid) forms inclusions.
- Quantification is possible with
 - **Collimator** measurements,
 - the **sum spectrum** of a map,
 - the **average values** of a sufficiently large set of point measurements.

Incoming goods inspection

Quantitative analysis – Copper alloys

Grade-IARM	Al	Co	Cr	Cu	Fe	Mn	Mo	Nb	Ni	P	Pb	Si	Sn	Ti	V	W	Zn	Zr
CDA314-72B	T	T	T	90.1	0.0	T	T	T	0.0	0.0	2.0	0.0	0.0	T	T	T	7.8	T
CDA360-73B	0.0010	0.0	T	61.5	0.2	0.0	T	T	0.1	0.0	2.7	0.0	0.2	T	T	T	35.3	T
CDA485-76B	0.0050	0.0	T	60.5	0.1	0.0	T	T	0.0	0.0	1.9	T	0.7	T	T	T	36.7	T
CDA510-77B	0.0010	T	T	95.2	0.0	0.0	T	T	0.0	0.1	0.0	0.0	4.7	T	T	T	0.0	T
CDA544-78B	0.0020	T	T	87.7	0.0	0.0	T	T	0.1	0.2	3.9	T	4.7	T	T	T	3.6	T
CDA623-79B	9.1900	0.0	0.0	88.4	2.1	0.2	T	T	0.1	0.0	0.0	0.0	0.0	T	T	T	0.0	T
CDA630-80B	10.1900	0.0	0.0	81.2	3.3	0.5	T	T	4.7	0.0	0.0	0.0	0.0	T	T	T	0.1	T
CDA642-81B	6.7000	T	0.0	91.2	0.0	0.0	T	T	0.0	0.0	0.0	1.8	0.0	T	T	T	0.2	T
CDA655-82B	0.0020	T	0.0	95.3	0.1	1.0	T	T	0.0	0.0	0.0	3.2	0.0	T	T	T	0.4	T
CDA706-84B	0.0020	0.0	0.0	87.9	1.3	0.6	T	T	10.0	0.0	0.0	0.0	0.0	T	T	T	0.1	T
CDA836-86C	0.0020	T	T	84.6	0.2	0.0	T	T	0.3	0.0	5.0	0.0	4.4	T	T	T	5.4	T
CDA857-87B	0.2000	0.0	0.0	60.9	0.3	0.0	T	T	T	0.0	1.6	0.0	0.8	T	T	T	36.1	T
CDA932-91C	0.0020	T	T	83.2	0.0	0.0	T	T	0.5	0.1	6.8	0.0	6.8	T	T	T	2.6	T
CDA937-BS937B-1	T	T	T	80.2	0.0	T	T	T	0.4	0.0	9.2	T	9.7	T	T	T	0.0	T

- (Type-)calibration of the M4 TORNADO's FP quantification needs reference materials.
- Measure sets of samples of known composition and quantify them.



- The initial correlation already is usually very linear.
- The slopes of the correlation may need to be adapted (=calibrated).



Incoming goods inspection

Quantitative analysis – Copper alloys

Grade-IARM	Al	Co	Cr	Cu	Fe	Mn	Mo	Nb	Ni	P	Pb	Si	Sn	Ti	V	W	Zn	Zr
CDA314-72B	T	T	T	90.1	0.0	T	T	T	0.0	0.0	2.0	0.0	0.0	T	T	T	7.8	T
CDA360-73B	0.0010	0.0	T	61.5	0.2	0.0	T	T	0.1	0.0	2.7	0.0	0.2	T	T	T	35.3	T
CDA485-76B	0.0050	0.0	T	60.5	0.1	0.0	T	T	0.0	0.0	1.9	T	0.7	T	T	T	36.7	T
CDA510-77B	0.0010	T	T	95.2	0.0	0.0	T	T	0.0	0.1	0.0	0.0	4.7	T	T	T	0.0	T
CDA544-78B	0.0020	T	T	87.7	0.0	0.0	T	T	0.1	0.2	3.9	T	4.7	T	T	T	3.6	T
CDA623-79B	9.1900	0.0	0.0	88.4	2.1	0.2	T	T	0.1	0.0	0.0	0.0	0.0	T	T	T	0.0	T
CDA630-80B	10.1900	0.0	0.0	81.2	3.3	0.5	T	T	4.7	0.0	0.0	0.0	0.0	T	T	T	0.1	T
CDA642-81B	6.7000	T	0.0	91.2	0.0	0.0	T	T	0.0	0.0	0.0	1.8	0.0	T	T	T	0.2	T
CDA655-82B	0.0020	T	0.0	95.3	0.1	1.0	T	T	0.0	0.0	0.0	3.2	0.0	T	T	T	0.4	T
CDA706-84B	0.0020	0.0	0.0	87.9	1.3	0.6	T	T	10.0	0.0	0.0	0.0	0.0	T	T	T	0.1	T
CDA836-86C	0.0020	T	T	84.6	0.2	0.0	T	T	0.3	0.0	5.0	0.0	4.4	T	T	T	5.4	T
CDA857-87B	0.2000	0.0	0.0	60.9	0.3	0.0	T	T	T	0.0	1.6	0.0	0.8	T	T	T	36.1	T
CDA932-91C	0.0020	T	T	83.2	0.0	0.0	T	T	0.5	0.1	6.8	0.0	6.8	T	T	T	2.6	T
CDA937-BS937B-1	T	T	T	80.2	0.0	T	T	T	0.4	0.0	9.2	T	9.7	T	T	T	0.0	T

CONFIGURATION - SPECTRUM ELEMENTS

Elements

H

Li

Be

Na

Mg

K

Rb

Cs

Fr

Ra

Ac

Ti

Zr

Hf

Ta

W

Re

Os

Ir

Pt

Au

Hg

Tl

Pb

Bi

Po

At

Rn

Sc

Y

Ba

La

Ce

Pr

Nd

Pm

Sm

Eu

Gd

Tb

Dy

Ho

Er

Tm

Yb

Lu

V

Nb

Mo

Tc

Ru

Rh

Pd

Ag

Cd

In

Sn

Sb

Te

I

Xe

Cr

Mn

Fe

Co

Ni

Cu

Zn

Ga

Ge

As

Se

Br

Kr

Al

Si

P

S

Cl

Ar

Ne

He

☒ Use spectrum elements

☒ Use list elements

☐ Search additional elements

Double click an element to open element editor

Clear all

Special properties of selected elements

Compound	Fix %	Dec.	Diff.	Fact.
				1.00
Cu				0.92
Zn				0.91
Rh				1.00
Pb				1.37

Compound

Stoichiomet. elements

Fix concentration

Deconvolution only

Excluded element

Difference element

Global options

Background cycles

Default

Manual

120

Minimum concentration

0.00 %

☒ NNLS

Description

Load...

Save...

OK

Cancel

Cu

$y = 1.0003x$
 $R^2 = 0.994$

Zn

$y = 1.0099x$
 $R^2 = 0.9996$

Pb

$y = 0.7174x$
 $R^2 = 0.9995$

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Innovation with Integrity |

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Incoming goods inspection

Quantitative analysis – Copper alloys

Grade-IARM	Al	Co	Cr	Cu	Fe	Mn	Mo	Nb	Ni	P	Pb	Si	Sn	Ti	V	W	Zn	Zr
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CDA623-79B	9.1900	0.0	0.0	88.4	2.1	0.2	T	T	0.1	0.0	0.0	0.0	0.0	T	T	T	0.0	T
CDA630-80B	10.1900	0.0	0.0	81.2	3.3	0.5	T	T	4.7	0.0	0.0	0.0	0.0	T	T	T	0.1	T
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CDA857-87B	0.2000	0.0	0.0	60.9	0.3	0.0	T	T	T	0.0	1.6	0.0	0.8	T	T	T	36.1	T
CDA932-91C	0.0020	T	T	83.2	0.0	0.0	T	T	0.5	0.1	6.8	0.0	6.8	T	T	T	2.6	T
CDA937-BS937B-1	T	T	T	80.2	0.0	T	T	T	0.4	0.0	9.2	T	9.7	T	T	T	0.0	T

CONFIGURATION - SPECTRUM ELEMENTS

Elements

☒ Use spectrum elements

☒ Use list elements

☐ Search additional elements

H

Li

Be

Na

Mg

K

Rb

Sr

Cs

Ba

Fr

Ra

Ac

Ce

Pr

Nd

Pm

Sm

Eu

Gd

Tb

Dy

Ho

Er

Tm

Yb

Lu

Th

Pa

U

Np

Pu

Am

Cm

Bk

Cf

Es

Fm

Md

No

Lr

B

C

N

O

F

Ne

Al

Si

P

S

Cl

Ar

Cr

Mn

Fe

Co

Ni

Cu

Zn

Ga

Ge

As

Se

Br

Kr

Ag

Cd

In

Sn

Sb

Te

I

Xe

Hg

Tl

Pb

Bi

Po

At

Rn

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Special properties of selected elements

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Zn				0.91
Rh				1.00
Pb				1.37

Compound

Stoichiomet. elements

Fix concentration

Deconvolution only

Excluded element

Difference element

Global options

Background cycles

☐ Default

☒ Manual

120

Minimum concentration

0.00

%

☒ NNLS

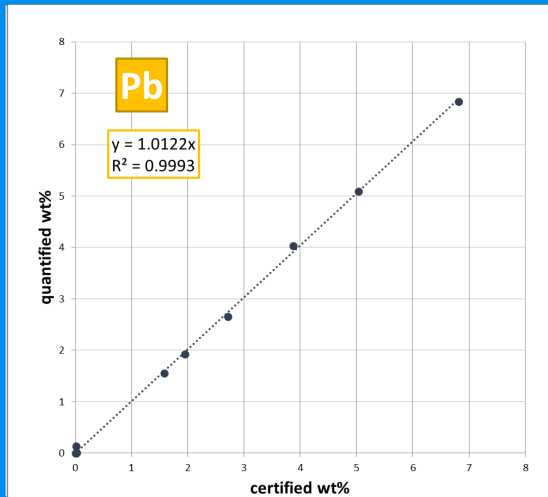
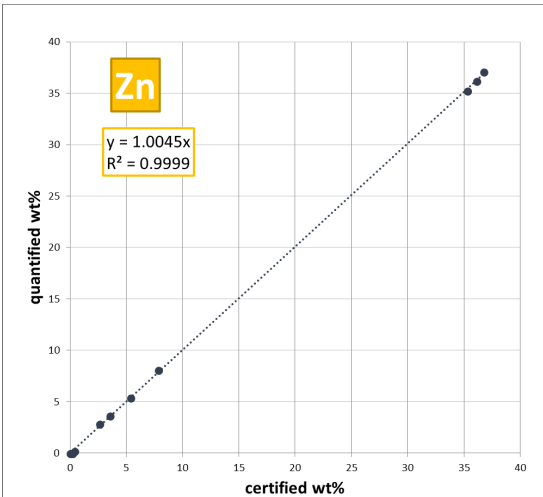
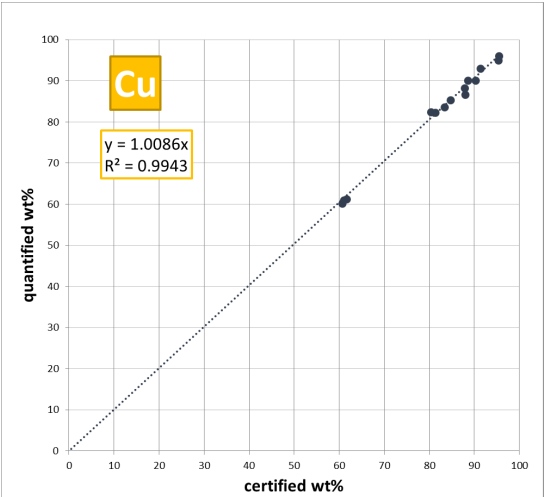
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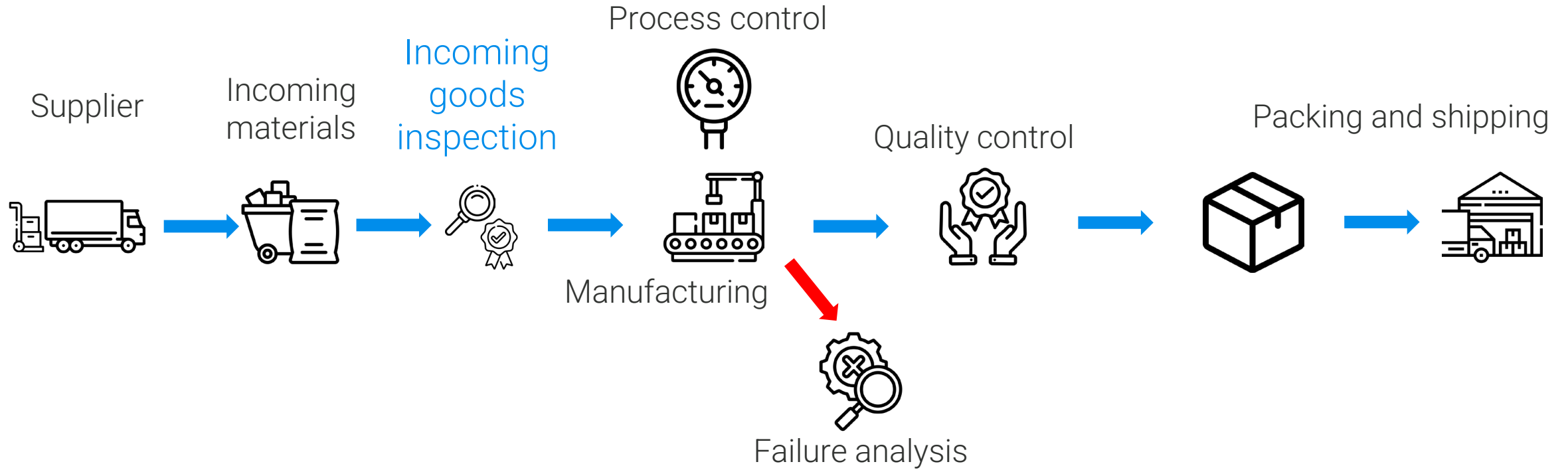
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OK

Cancel



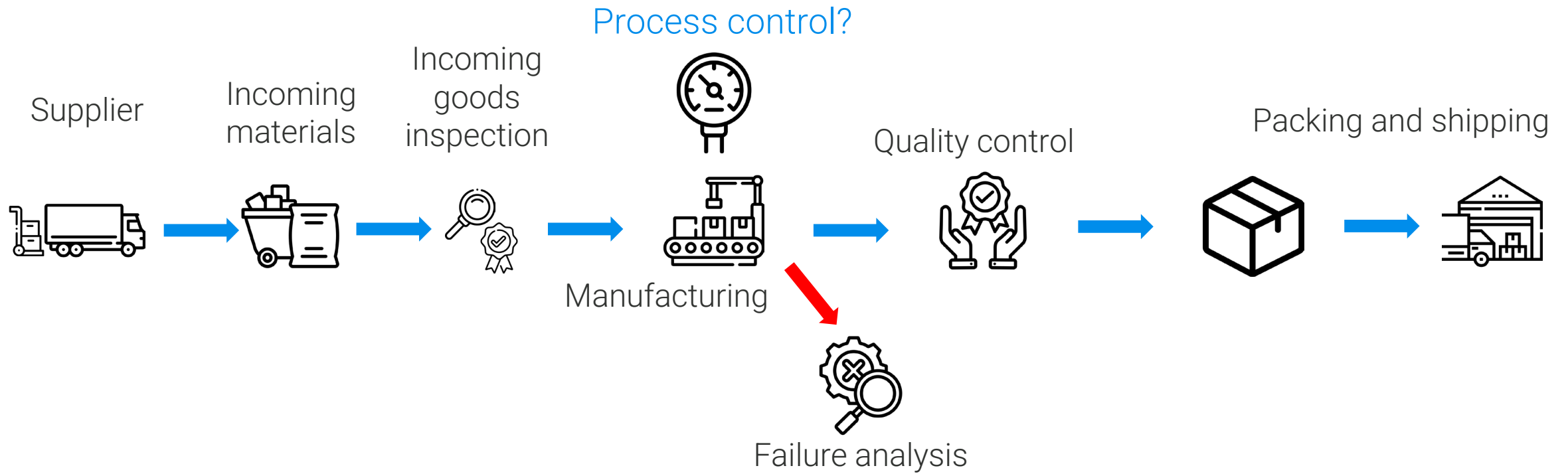
Micro-XRF – Quality control at different stages



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Micro-XRF – Quality control at different stages

Process control

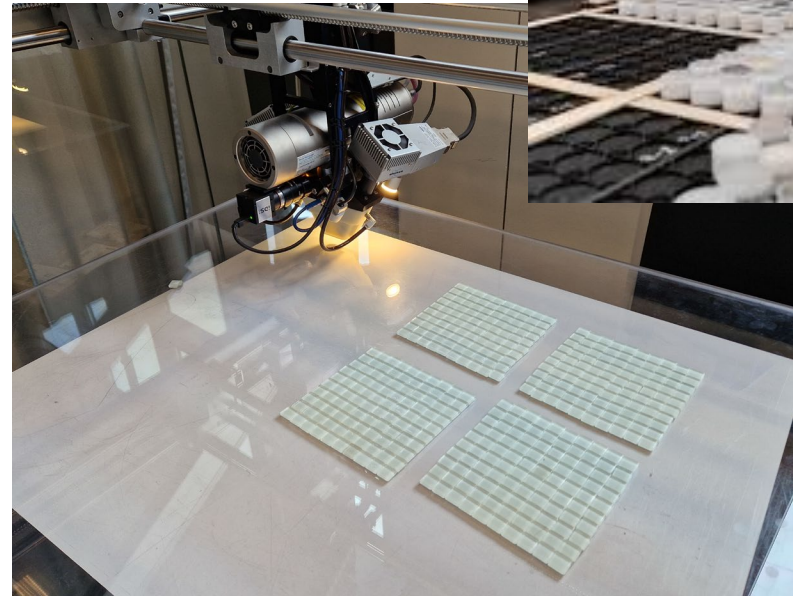


Icons made by Freepik and Uniconlabs
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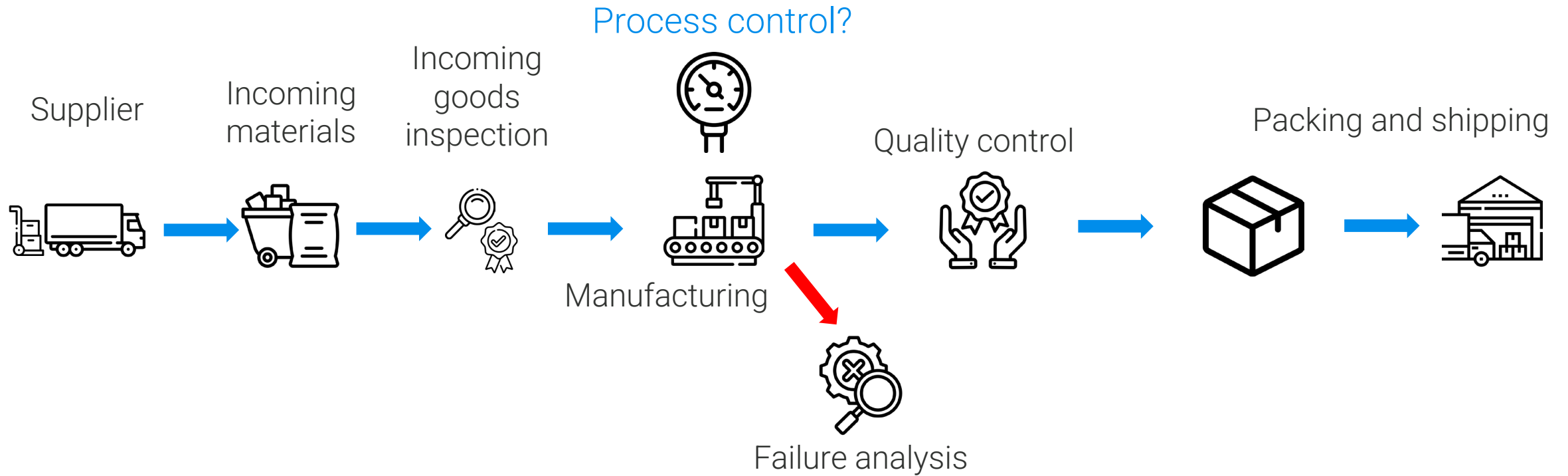
Process control

Is it feasible?

- True on-line analysis with XRF is possible – but with micro-XRF it is ... challenging.
- (semi-)automated point measurements with open-beam instruments are the immediate application.



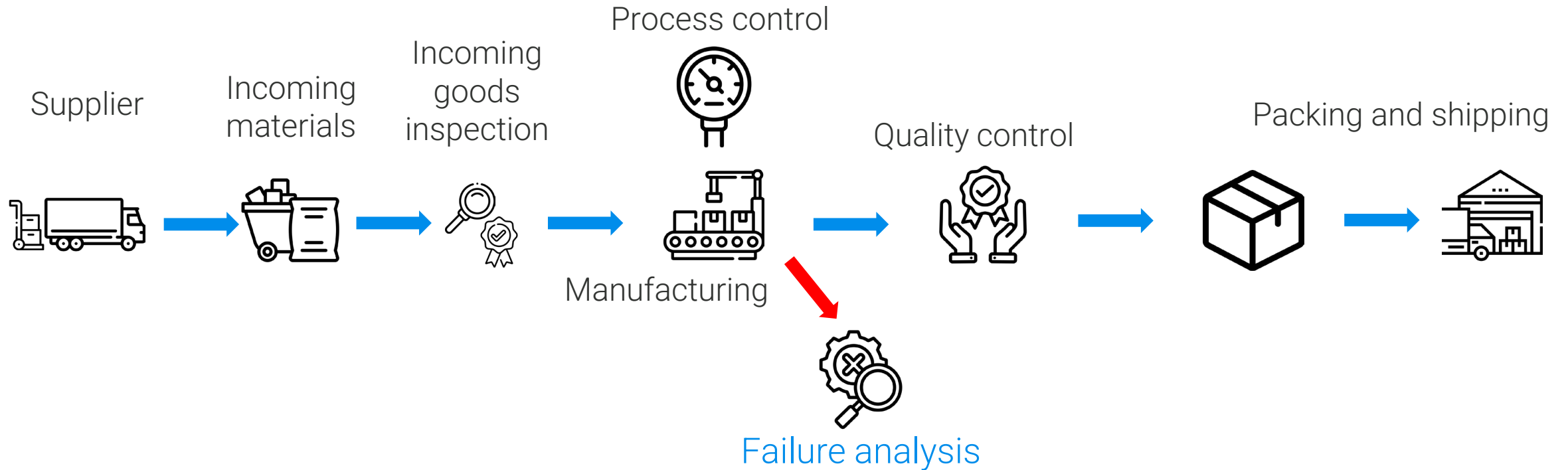
Micro-XRF – Quality control at different stages



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Micro-XRF – Quality control at different stages

Failure analysis



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from www.flaticon.com

Failure analysis

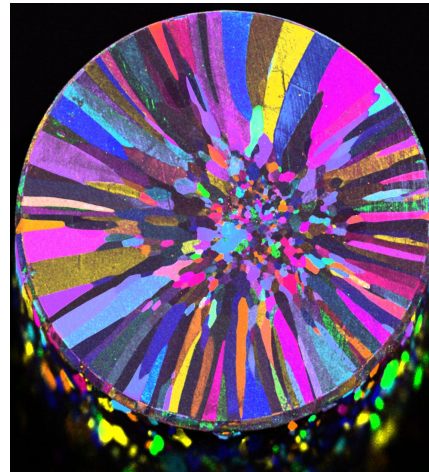
Example – Stripped threads in aluminium



- Al 6063 is a commonly used aluminium alloy, well suited for aluminium extrusion with smooth surfaces that allow for anodizing.
- In one batch of products, it was not possible to insert the screws as usual because the threads could not withstand the mechanical stresses.
- In aluminium, even more than in other alloys, the mechanical properties are not only a matter of composition but above all of microstructure, which can be finely tuned by heat treatment (temper).



- Sometimes even the crystalline structure can be resolved by micro-XRF.





Failure analysis

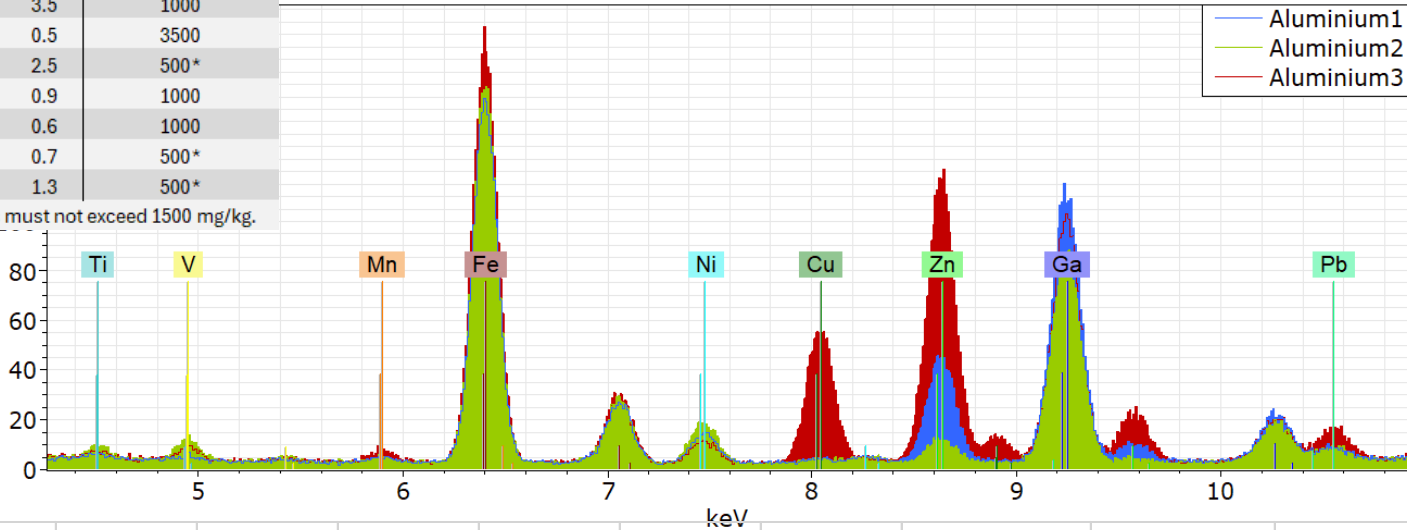
Alloy element quantification

Element	Aluminium 1			Aluminium 2			Aluminium 3			Al 6063 grade composition (upper limit) / mg/kg
	concentration / mg/kg	uncertainty / mg/kg	/ %	concentration / mg/kg	uncertainty / mg/kg	/ %	concentration / mg/kg	uncertainty / mg/kg	/ %	
Ti	60	3	5.0	180	5	2.9	60	3	5.5	1000
V	20	1	6.8	160	4	2.5	80	3	3.8	500*
Mn	20	1	4.1	20	1	4.2	40	1	3.5	1000
Fe	860	4	0.5	890	5	0.5	980	5	0.5	3500
Ni	30	1	1.8	40	1	1.5	20	0.9	2.5	500*
Cu	1	0.1	9.1	2	0.12	5.9	100	1	0.9	1000
Zn	60	1	0.9	10	0.2	2.0	150	1	0.6	1000
Ga	110	1	0.6	90	1	0.6	90	1	0.7	500*
Pb	5	0.1	1.9	5	0.1	1.9	15	0.2	1.3	500*

* - not graded. "Other" elements may be concentrated up to 500 mg/kg, but the sum of their concentrations must not exceed 1500 mg/kg.

Quantified results

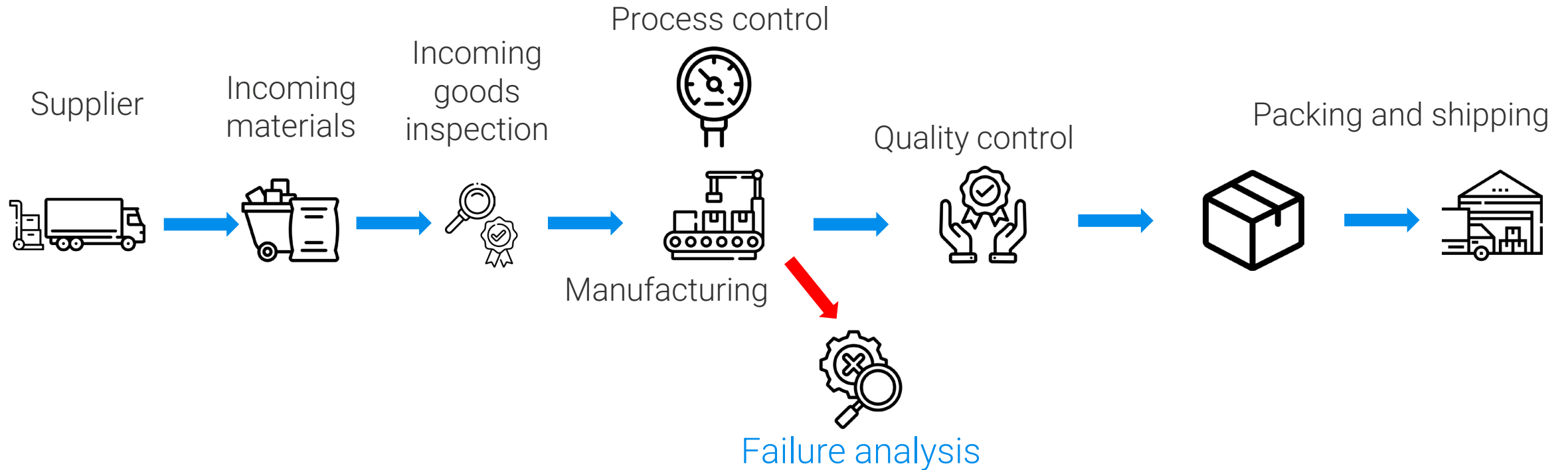
Spectra of the samples



Grade limits of selected Al alloys

											residuals	Density	Young's modulus	Ultimate	Thermal
Aluminium	Mg	Al	Si	Ti	Cr	Mn	Fe	Cu	Zn	residuals		Density	Young's modulus	tensile strength	expansion
grades	/ wt%	/ wt%	/ wt%	/ wt%	/ wt%	/ wt%	/ wt%	/ wt%	/ wt%	each	total	/ g/cm³	/ GPa	/ MPa	/ 10 ⁻⁶ K ⁻¹
6060	0.35 - 0.5	97.9 - 99.3	0.3 - 0.6	0 - 0.1	0 - 0.05	0 - 0.1	0.1 - 0.3	0 - 0.1	0 - 0.15	0 - 0.05	0 - 0.15	2.71	70	70 - 180	23.4
6063	0.45 - 0.9	97.5 - 99.35	0.2 - 0.6	0 - 0.1	0 - 0.1	0 - 0.1	0 - 0.35	0 - 0.1	0 - 0.1	0 - 0.05	0 - 0.15	2.7	69	120(190*) - 240	23.4
6105	0.45 - 0.8	97.2 - 99.0	0.6 - 1	0 - 0.1	0 - 0.1	0 - 0.1	0 - 0.35	0 - 0.1	0 - 0.1	0 - 0.05	0 - 0.15	2.69	70	120 - 260	21.8
6463	0.45 - 0.9	97.9 - 99.4	0.2 - 0.6			0 - 0.5	0 - 0.15	0 - 0.2	0 - 0.05	0 - 0.05	0 - 0.15	2.69	70	130 - 230	22.1
														*T6 temper	

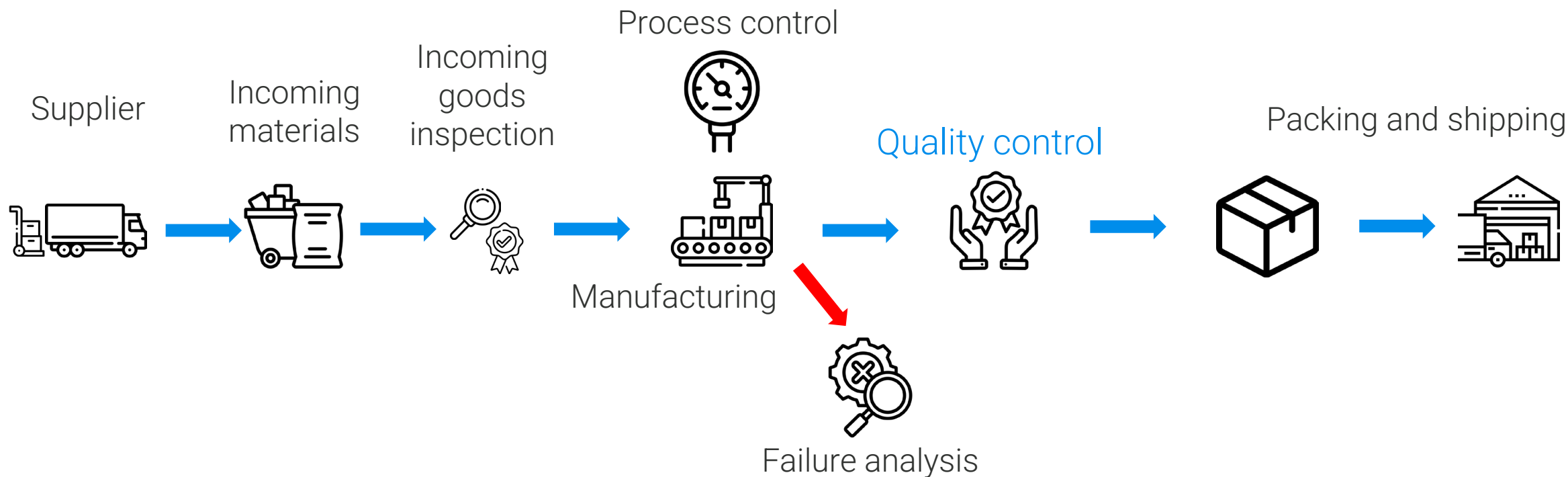
Micro-XRF – Quality control at different stages



Icons made by Freepik and Uniconlabs
from www.flaticon.com

Micro-XRF – Quality control at different stages

Quality control



Icons made by Freepik and Uniconlabs
from www.flaticon.com

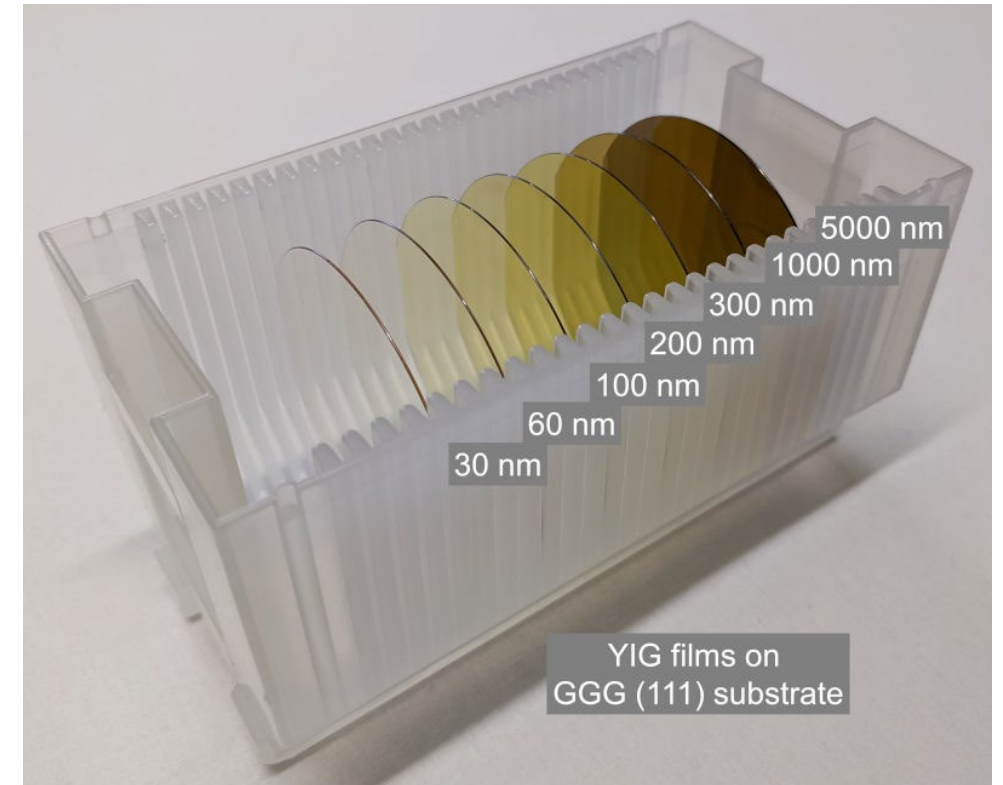
Quality control

YIG layer analysis

- Due to outstanding magnetic properties, Yttrium iron garnet (YIG) thin films grown on a lattice matched substrate (GGG, gadolinium gallium garnet) are increasingly being produced commercially.
- Important properties like magnetic damping factor scale with the thickness of the thin film.

→ Thickness needs to be quantified to gauge the material performance.

→ Micro-XRF may be used for this purpose.



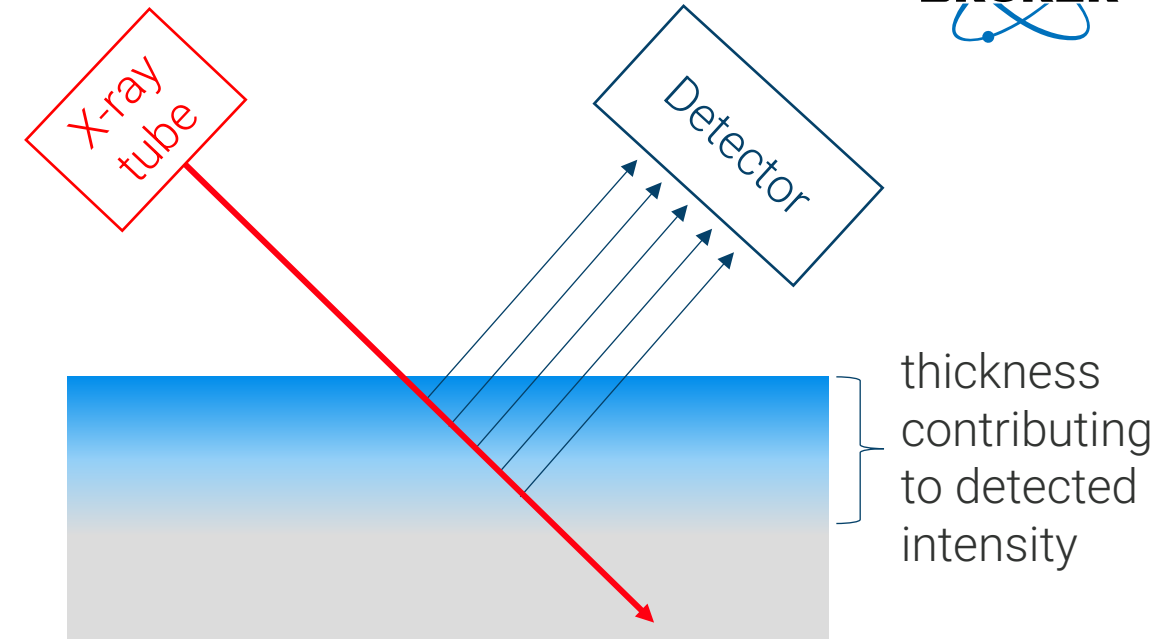
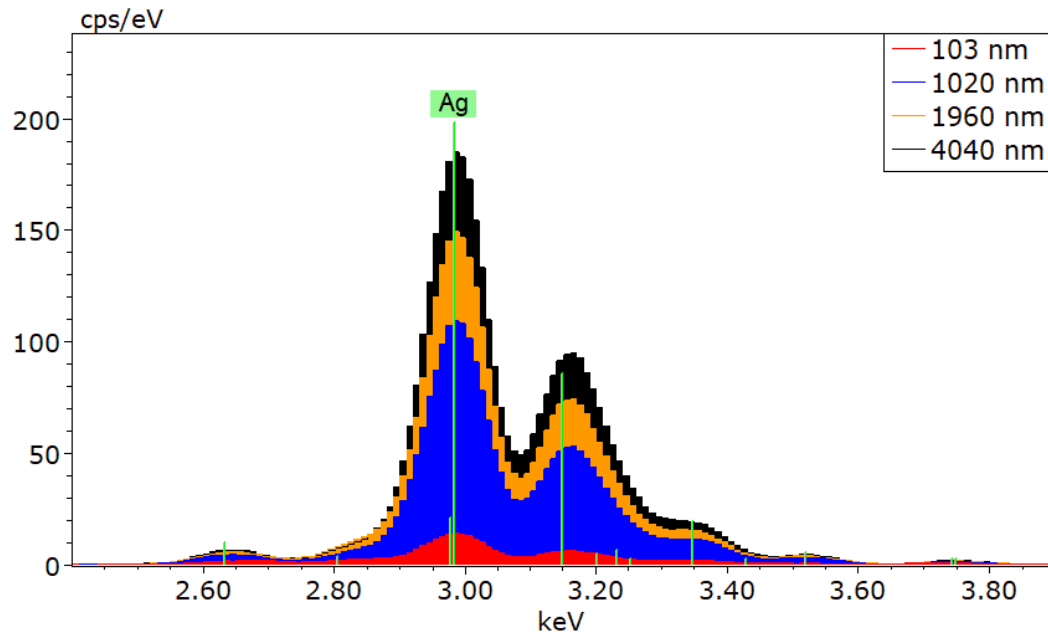
©Innovent e.V. – <https://www.innovent-jena.de/mos/yig>

Intro

Thickness analysis using micro-XRF

- X-rays can penetrate deeply into many materials.

→ Characteristic X-rays can be generated in varying sample depths.

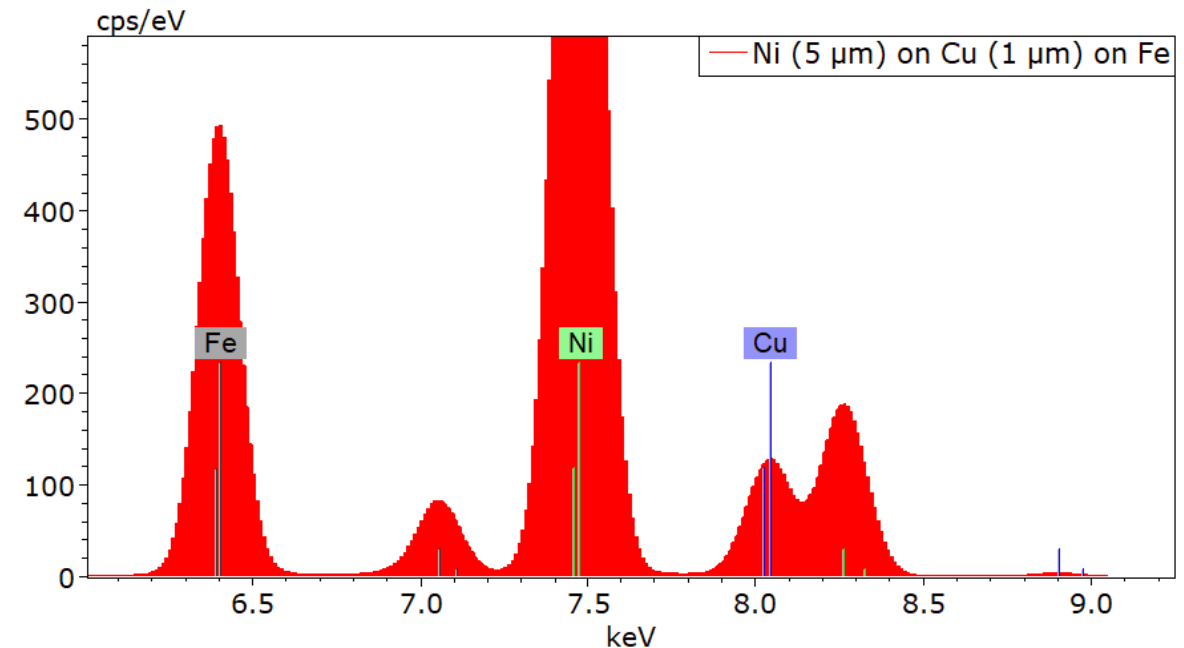
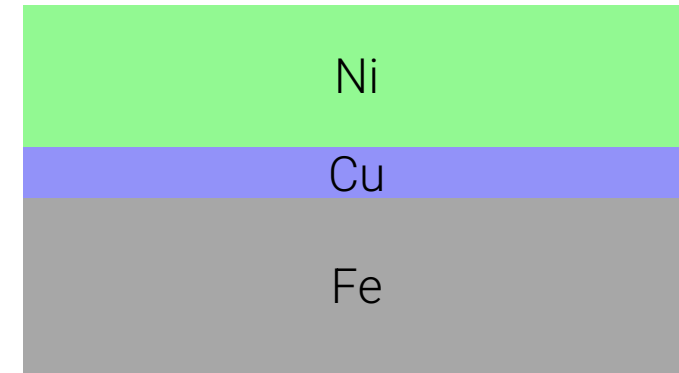


- X-rays from high depths will be absorbed before reaching the surface.
 - Detected intensities will increase with sample thickness up to a maximum.
 - Intensities of characteristic X-rays may be used to deduce layer thicknesses.

Intro

Thickness analysis using micro-XRF

- Interlayer effects are often important.
- Layer stacking needs to be known.
- Quantification may be done purely based on reference-materials or in a fundamental parameter based approach that may, but must not necessarily be calibrated using reference materials.



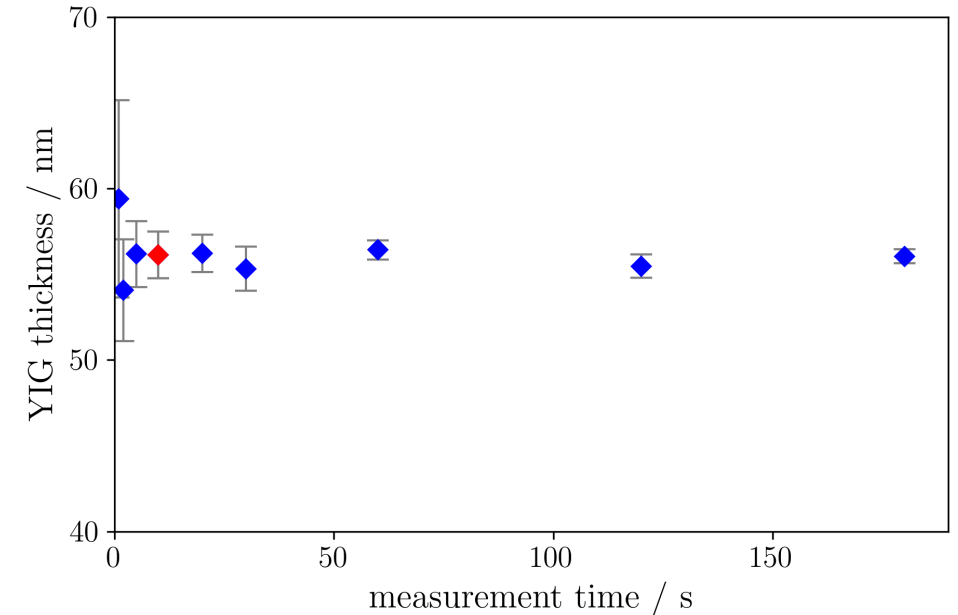
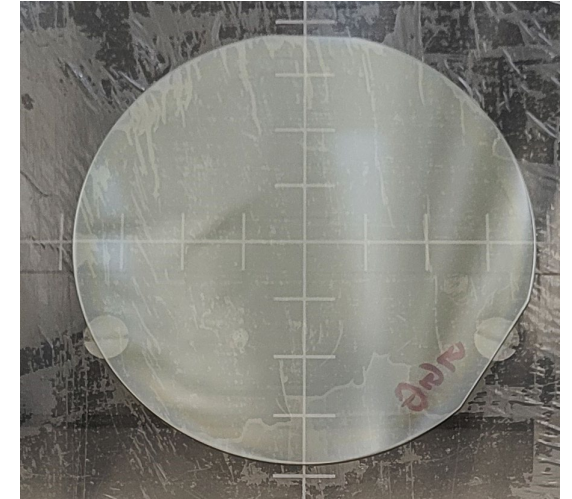
Quality control

YIG layer analysis – Measurement time I

- The objective of quality control might be to map variations in thickness of YIG on the sample surface.

→ Mappings or point analyses on a grid may be performed.

- Measurement time is a primary consideration. It is dictated by the required precision.
- For ~ 50 nm of YIG on GGG, measurements should likely not be less than 10 s (red marking) and anything above 60 s will not improve the results.



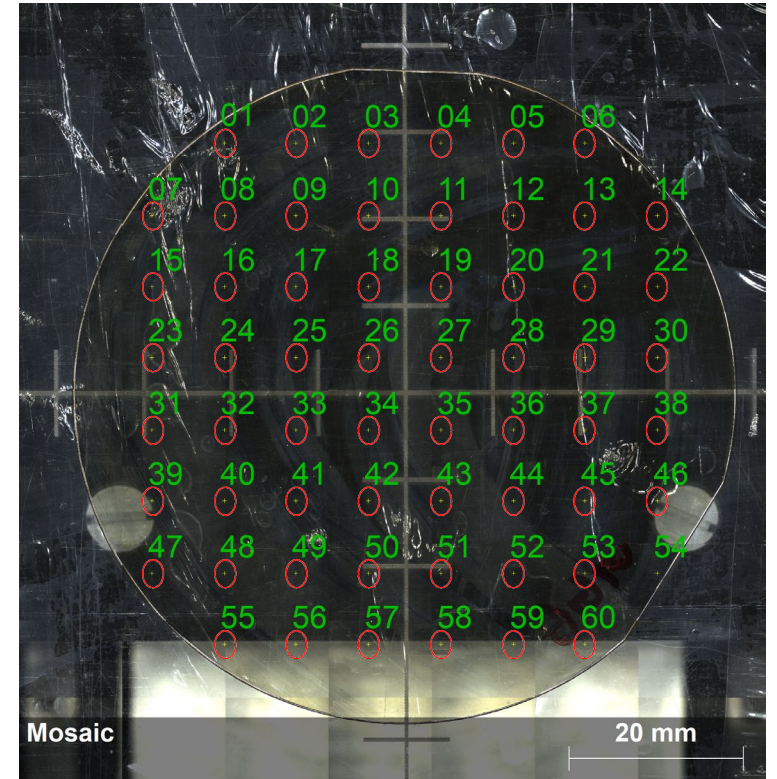
Quality control

YIG layer analysis – Measurement time II

- Given the required measurement times, doing point analyses rather than a mapping is more feasible.
- Decisions must be made regarding the number of points and time per point and will depend on what is required for the user.

Three options were explored:

1. 60 measurements on a grid with 60 s per spot (shown on right).
2. 60 measurements on a grid with 30 s per spot if lower precision is acceptable.
3. 120 measurements on a grid with 60 s per spot if a higher measurement time is acceptable.

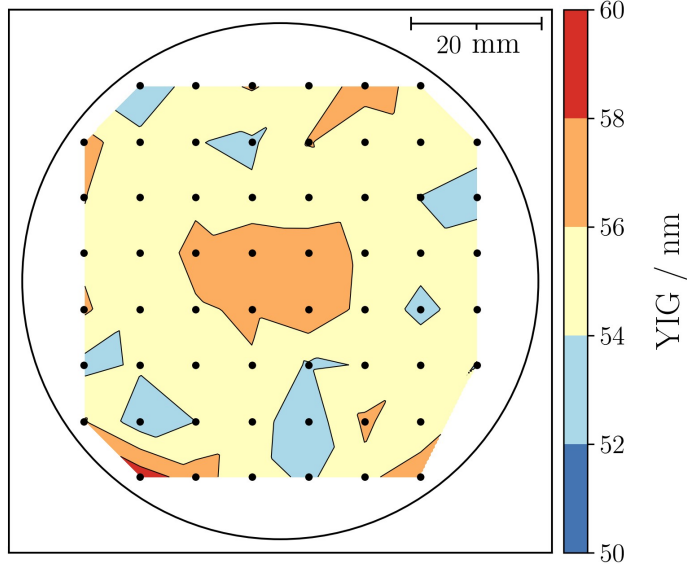


- To ensure that very localized variations are less reflected in the data, a 2000 μm collimator was used.

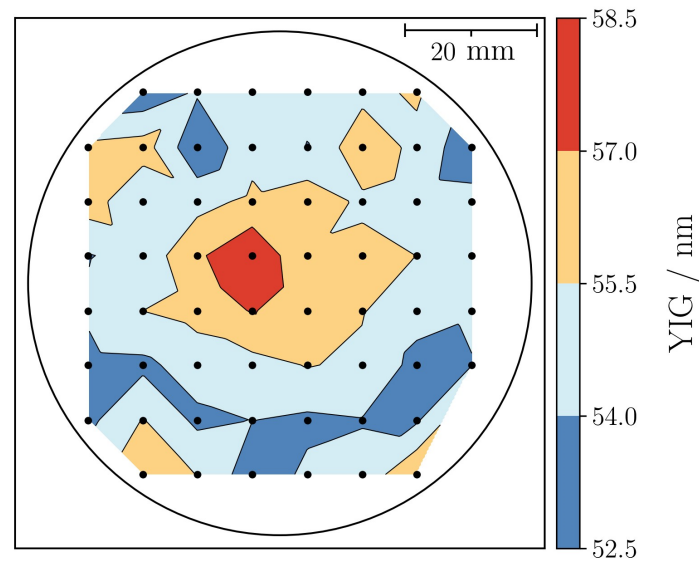
Quality control

YIG layer analysis – Layer thickness distribution

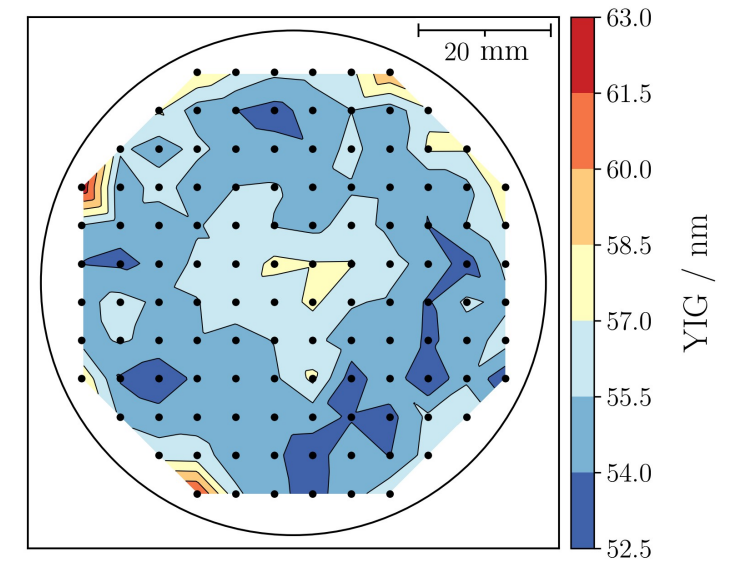
overall time: ~ 38 min



overall time: ~ 68 min



overall time: ~ 137 min

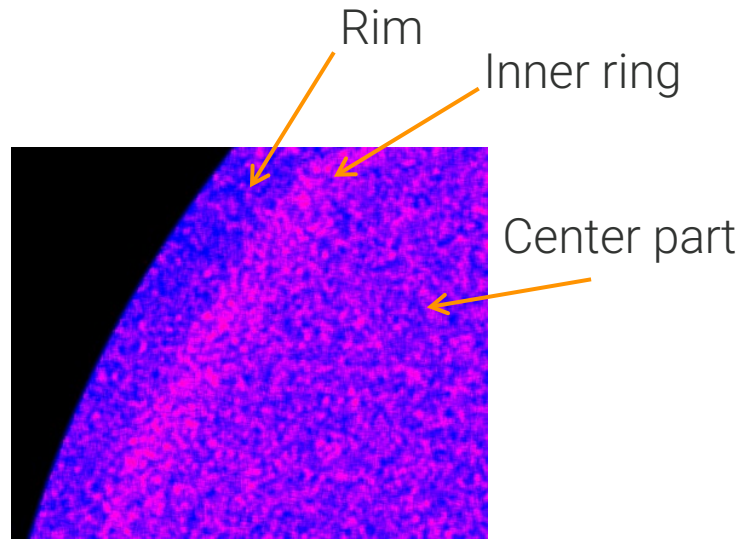


- All measurements show an increased thickness at the center.
- Denser map highlights often-times increasing thickness at the outside.
- Thicknesses were derived without introducing reference materials. YIG thickness according to XRR: 53 nm.

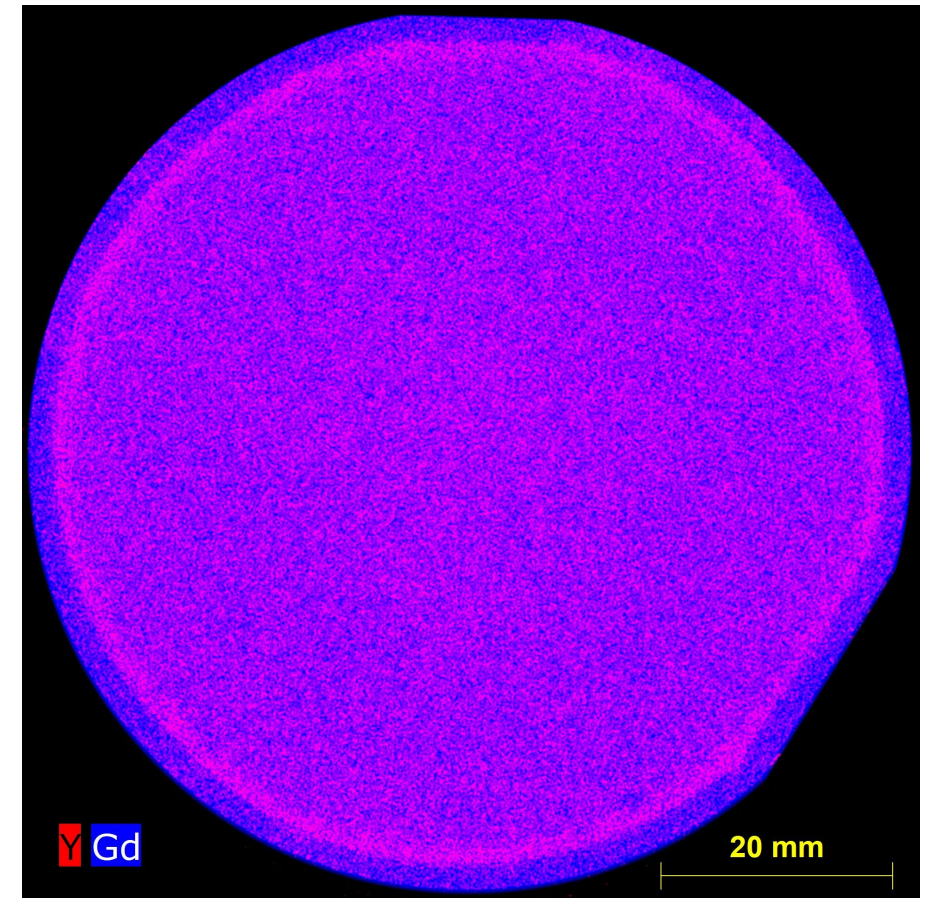
Quality control

YIG layer analysis – Rim structure

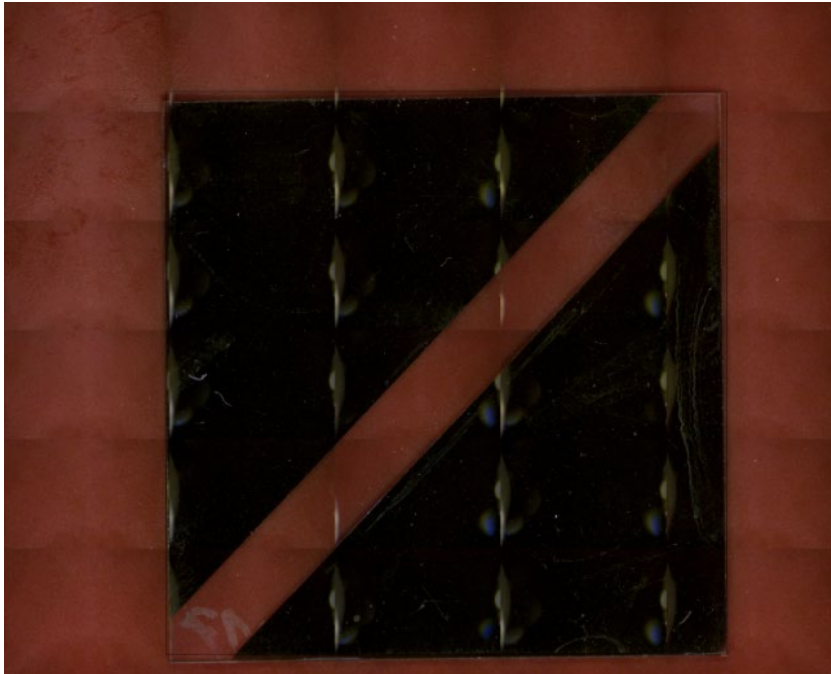
- A map with a polycapillary optic reveals the origin of the anomalies close to the edge.
- There is an outer ring with ~ 2.3 mm width, where very little YIG was deposited, followed by an ~ 1.7 mm inner ring with increased loading.
- Depending on which part of this ring structure at the edge was hit by the larger X-ray spots, either an increased or decreased thickness of YIG was quantified.



overall time: ~ 14 h 30 min



Quality control Components for PEC cells



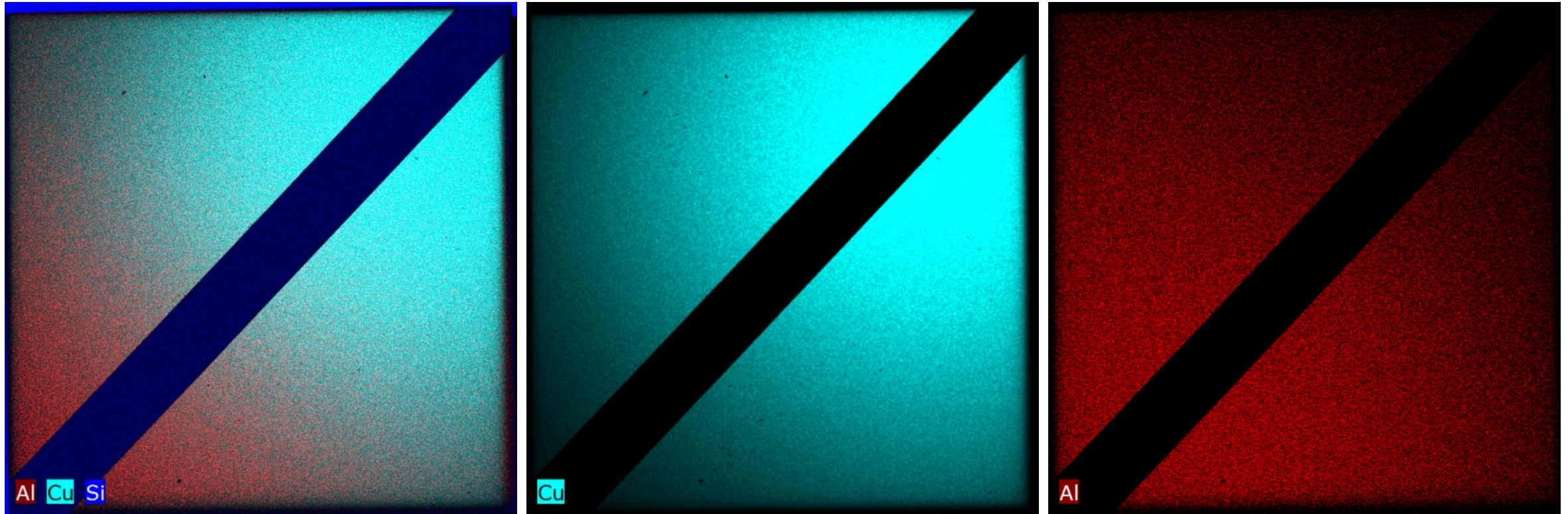
Cu:Al gradient layer, manufactured through magnetron sputtering of a dual Cu/Al target by K. Harbauer, W. Kohrt, K. Ellmer, Helmholtz-Zentrum Berlin für Materialien und Energie

- Photoelectrochemical (PEC) cells can produce hydrogen from water when exposed to sunlight.
- The efficiency of the process, as well as the stress due to corrosion depend strongly on a finely tuned set of technical parameters – layer thickness and composition is one of them.

Map information		
Mapping parameter		
Width:	1000	pixel
	50	mm
Height:	1000	pixel
	50	mm
Pixel Size:	50	µm
Total number of pixel:	1000000	pixel
Acquisition parameter		
Frame count:	1	
Pixel time:	50	ms/pixel
Measure time:	13:53 h	
Overall time:	14:58 h	
Tube parameter		
High voltage:	50	kV
Anode current:	200	µA
Filter:	Empty	
Optic:	Lens	
Chamber at:	Vacuum 20	mbar
Anode:	Rh	
Detector parameter		
Selected detectors:	1	
Close		

Quality control

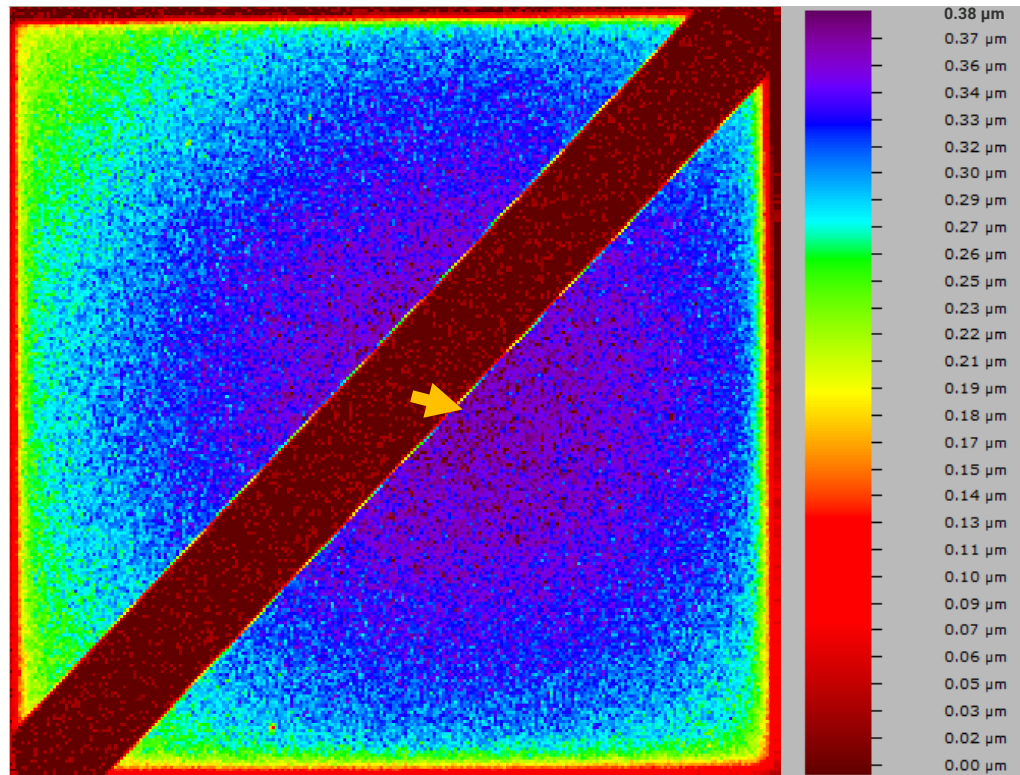
Components for PEC cells – Qualitative analysis



- Cu/Al-layer on a glass substrate: the concentration gradient is clearly visible

Quality control

Components for PEC cells – Layer thickness quantification



- Knowing the structure of the sample, a method for layer thickness analysis can be set up quickly.
- A full quantification of the map data (here with 5x5 binning) shows the layer **thickness** distribution with high spatial resolution (250 μm per pixel).
- ... but it also takes time.
- The radially symmetric distribution pattern is visibly offset from the center.

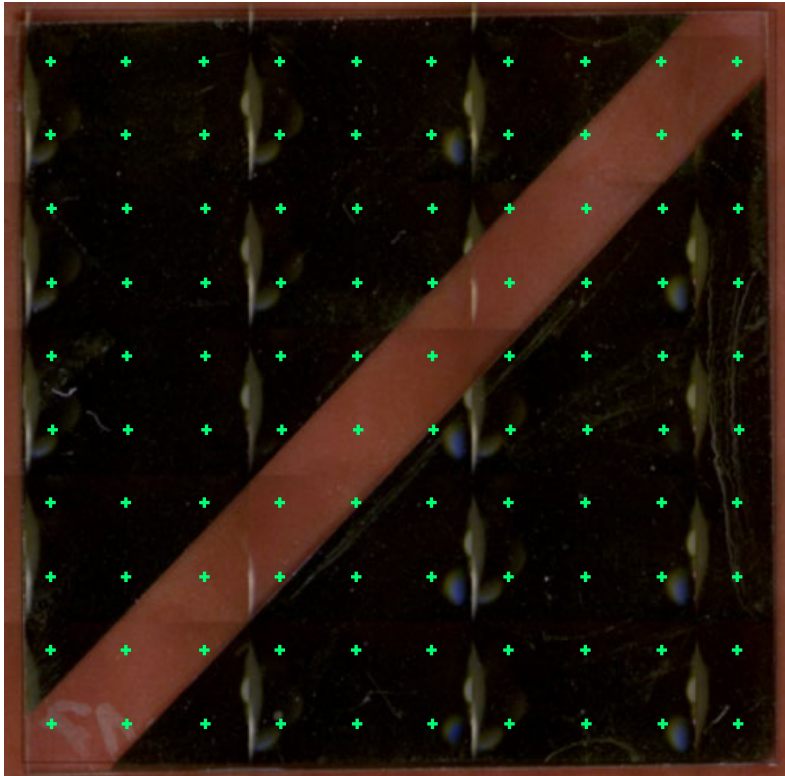
Structure		
Layer	Chemical elements	
layer1	Cu	Al
base	Si	

Measure conditions	
Parameter	Value
HV / kV	50
Current / μA	200
Collimator	25 μm LENS
Atmosphere	Vacuum

- Note: for sample systems like this there are no certified reference materials.
→ the quantification is based on fundamental parameters and known physics (and can be supported by samples of trusted composition).

Quality control

Components for PEC cells – Quantitative point analysis



- When the expected variations are on a millimeter-scale, there is no need to measure with micrometer resolution.
- To save measurement time, an array of points can be set and measured.
- Point spectra can be quantified using the same layer analysis method.
- The results (layer thicknesses and composition) are shown in tabular form and can be exported to text files.
- This allows, for example, to visualize the result of the element and layer thickness distribution.

- 10x10 grid.
- Measurement time per point is 10 s.

Quality control

Components for PEC cells – Comparison of results



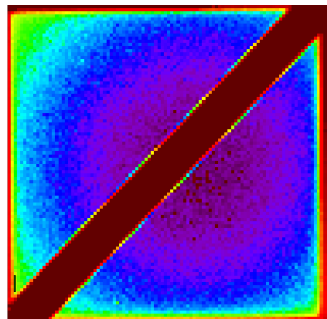
22.8	21.0	20.7	18.7	17.6	16.8	15.5	14.4	0.0	0.0
23.4	22.6	21.4	19.6	19.9	17.7	17.4	0.0	0.0	13.7
24.6	23.1	22.3	21.4	20.0	19.2	0.0	0.0	14.8	14.9
25.6	25.6	22.5	21.9	21.7	20.0	0.0	17.8	16.4	16.0
27.1	27.0	25.3	24.2	23.6	0.0	20.4	19.6	18.4	17.0
28.7	27.4	27.3	25.5	0.0	23.6	23.0	20.5	19.5	17.8
30.3	29.6	28.8	0.0	25.3	25.5	23.1	22.7	20.7	18.2
30.7	30.3	0.0	0.0	27.1	25.7	25.8	22.9	21.8	20.2
32.5	0.0	0.0	29.6	28.1	27.2	25.4	23.7	22.8	21.6
0.0	0.0	31.8	30.6	28.6	27.3	25.7	24.2	23.1	21.0

- Element distribution of Al (qualitative, left) shows maximum is not in the corner, the layer composition (quantitative, right) shows that the highest Al:Cu ratio (33:67) is in the bottom-left corner.



77.2	79.0	79.3	81.3	82.4	83.2	84.5	85.6	0.0	0.0
76.6	77.4	78.6	80.4	80.1	82.3	82.6	0.0	0.0	86.3
75.4	76.9	77.7	78.6	80.0	80.8	0.0	0.0	85.2	85.1
74.4	74.4	77.5	78.1	78.3	80.0	0.0	82.2	83.6	84.0
72.9	73.0	74.7	75.8	76.4	0.0	79.6	80.4	81.6	83.0
71.3	72.6	72.7	74.5	0.0	76.4	77.0	79.5	80.5	82.2
69.7	70.4	71.2	0.0	74.7	74.5	76.9	77.3	79.3	81.8
69.3	69.7	0.0	0.0	72.9	74.3	74.2	77.1	78.2	79.8
67.5	0.0	0.0	70.4	71.9	72.8	74.6	76.3	77.2	78.4
0.0	0.0	68.2	69.4	71.4	72.7	74.3	75.8	76.9	79.0

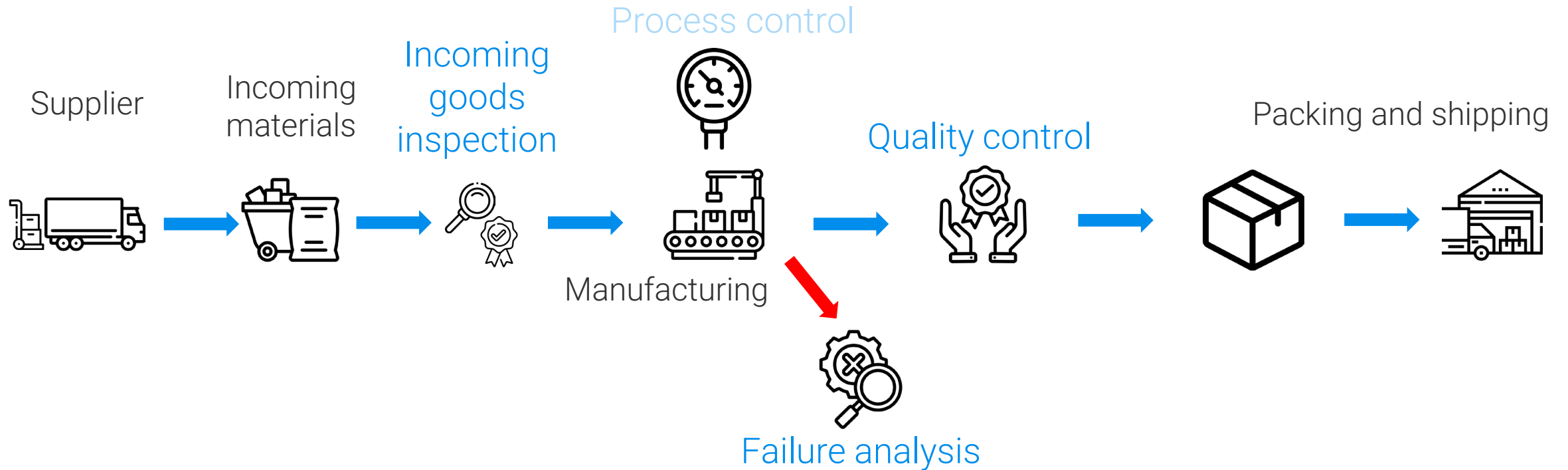
- Element distribution of Cu (qualitative, left)
- The layer composition (quantitative, right) shows the highest Cu:Al ratio (86:14) in the top-right corner.



0.239	0.259	0.291	0.301	0.311	0.321	0.325	0.314	0.000	0.000
0.258	0.287	0.307	0.318	0.346	0.340	0.350	0.000	0.000	0.300
0.269	0.298	0.322	0.342	0.355	0.361	0.000	0.000	0.332	0.316
0.277	0.314	0.324	0.347	0.369	0.366	0.000	0.367	0.347	0.327
0.284	0.325	0.342	0.359	0.378	0.000	0.372	0.370	0.355	0.331
0.283	0.312	0.346	0.360	0.000	0.379	0.386	0.367	0.357	0.324
0.281	0.314	0.338	0.000	0.301	0.382	0.369	0.370	0.355	0.309
0.264	0.294	0.000	0.000	0.350	0.356	0.370	0.347	0.337	0.305
0.249	0.000	0.030	0.319	0.326	0.342	0.336	0.327	0.319	0.291
0.000	0.000	0.274	0.289	0.295	0.303	0.302	0.295	0.286	0.256

- Very similar results with respect to position and min/max-values of the layer thickness distribution.
- Spatial resolution vs. measurement time (here 250 μm with 15 h vs. 5 mm with < 20 min)

Summary

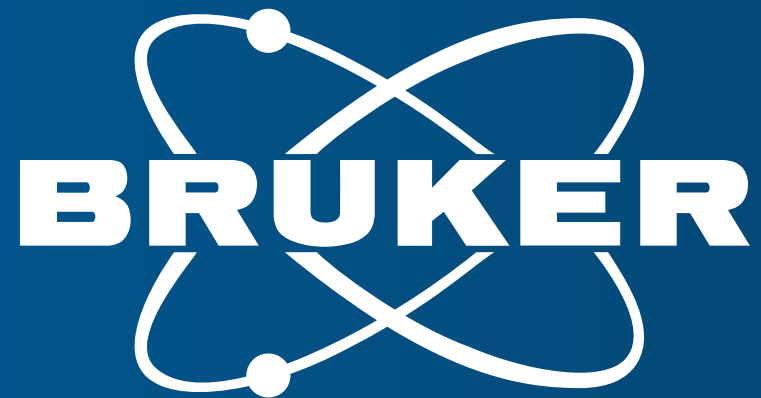


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Thank you!

Are there any questions?

For more information, please contact us:
info.bna@bruker.com



Innovation with Integrity